







CE marking is a mandatory mark for certain product groups to indicate conformity CE marking is a mandatory mark for certain product groups to indicate conformity with the essential health and safety requirements set out in European Directives.



X ACCRETECH

CE

Surface Texture · Contour Measuring Instruments >>>



SURFCOM 3000A



SURFCOM 3000A-DX

World's Highest Performance

The SURFCOM 3000A is an integrated surface texture and contour measuring instrument that sets a new paradigm for precision and performance. Resolution is 0.005 μ m and the ratio of dynamic range to revolution is 2,400,000 : 1.

Analysis of Surface Texture/Profile in One Measurement

The 3000A is provided with ACCRETECH's TIMS integrated measuring system featuring high flexibility and expandability. This enables extremely efficient analysis of surface texture and contour profile in only one trace operation.

Easy to Operate

A variety of measuring assist functions are incorporated, including an AI function, trace display function, repeat function and auto calculation range expansion function. This makes the unit easy to operate even for beginners.



SURFCOM 3000A-STD



* Printer is option.

Highly Stable Double-Beam Path-Type Laser Interference Sensor (patented)

Our optical-fiber based laser interference measuring system has been applied to develop a highly stable double-beam path-type laser interference sensor with 0.005 μ m resolution and a ratio of dynamic range to revolution of

2,400,000 : 1. This revolutionary system enables one-trace evaluation of contour profile and the minute hidden surface profile.



Wide Range · Automatic Measurement

The 3000A has a wide range of 200 mm in the horizontal direction and 12 mm in the vertical direction. It has a motor-driven tilting unit that can tilt 45°, and teaching/playback function that enables automation of everything from measurement to printout.



AI Function

Line, circle or other element can be automatically determined by simply specifying the profile analysis range. This is a representation of our commitment to making measurements as easy as possible.



ACCRETECH TOKYO SEIMITSU

Measurement

Simply Set Measuring Length

The trace input method where the measuring range is specified after a manual trace is effective for precise micro-profile positioning. This also reflects our commitment to making measurements as easy as possible. The conventional method of setting the measuring distance from the starting point can also be used.

Trace display

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Analysis

Measured results Dimension Line Display The diameter, angle, pitch and other actual measured values can be

entered onto the dimension lines on the measured result diagram. In addition, geometric deviation of roundness, straightness and other values, and surface texture can also be displayed. Calculation Result/Design Value

Collation Function

This function enables one-glance OK/NG judgment for tolerance collation. The operator does not have to make a pass/fail judgment.

External Output Function

Measured results can be output as a CSV file. This CSV file can be read by a standard spreadsheet program.

Profile Evaluation **Best Fit Function**

In order to minimize the error between the differences in the standard settings for the design values and measured values to be compared, the coordinate system with the minimum error between the design/measured values is obtained, and error collation is performed for the profile data at each point.



Printing

Printout The results of surface texture and contour profile analysis are output on a single inspection report.



Specifications

Model		SURFCO	M 3000A				
Model		Surface Texture Evaluation	Contour Evaluation				
Measuring range	Z axis (vertical)	12mm for 50mm arm,	24mm for 100mm arm				
	X axis (horizontal)	200 mm					
Accuracy	Z axis indication accuracy (vertical)	\pm (0.3 + 2H / 100) μ m (H: Measuring height [mm])					
	Resolution	5nm for 50mm arm, 10nm for 100mm arm					
	X axis indication accuracy (horizontal)	\pm (0.5 + L / 200) μ m (L: Measuring length [mm])					
	Sampling interval	0.05 –	20 μm				
Straightness accur	асу	(0.05 + 1.5L	_ / 1000) μm				
Sensing method	Z axis (vertical)	Highly stable double-beam pat	h-type laser interference sensor				
	X axis (horizontal)	Beam diffra	action scale				
Processing functions	Parameters / calculation processing	Complies with JIS-2001, JIS-1994, JIS-1982, ISO-1997, ISO-1984, DIN-1990, ASME 1995 & CNOMO	Point, line, circle, partial circle, ellipse, max. point/min. point, distance, coordinate difference, polar coordinate difference, orthogonal/polar coordinate difference display, intersecting elements (point-line, line-line, circle-line,				
		ASIME-1995 & CINOMO	circle-circle, line-ellipse), symmetric elements				
		ra, rq, ry, rp, rv, rc, rz, rillax, rl,	circle-ellipse, ellipse- ellipse), surface calculation,				
		R_{A0} TILT A Ir R_{C} Rek Rku Rk	over-pin calculation, dimension line display function, calculation result/design value collation, mirror reversal.				
		$R_{\rm r}$ Rok Ryk Mr1 Mr2 VO K to Rmr	profile synthesis function, macro function,				
		$Bmr2$ $B\delta c$ AVH Hmax Hmin ABEA	workpiece trace function, peak and valley function,				
		NCRX, R, Rx, AR, NR, CPM, SR, SAR	auto operation log/playback function, profile design value collation, best fit, design value generation, IGES/DXF conversion				
Evaluation curves		Section profile curve, roughness curve, filtered waviness curve, filtered center line waviness curve, rolling circle waviness curve, rolling circle center line waviness curve, DIN4776 special curve, roughness motif curve, waviness motif curve, envelope waviness curve	_				
	Surface characteristic	Load curve, power graph, amplitude distribution (ADF) graph	-				
	Tilt correction / standard setting	Linear correction, round surface correction, first half correction, latter half correction, both end correction, spline curve correction (linear, round surface and both end correction possible at arbitrary range)	Zero point setting, X axis setting, parallel movement, rotary movement				
Speed	Column up/down (Z axis)	3.10	mm/s				
	Measuring (X axis)	0.02 – 1 mm/s (Movemer	nt speed: 0.02 – 20 mm/s)				
Drive unit	Tilting device	±45° motor	ized/manual				
Sensor unit	Stylus	Repla	ceable				
	Measuring force	0.7 mN/ 16	mN or less				
	Stylus radius	2 μ m R60° cone for 50mm a	rm, 500 μ m R for 100mm arm				
	Stylus material	Diamor	nd / ruby				
Power source		Single phase AC 10	00 V ±10%, 50/60 Hz				
Power consumption	n	450) VA				
Installation dimens	ions	2100 (W) × 900 (D) × 1650 (H) mm				
Weight		350	0 kg				





Model with Three-Dimensional Roughness Analysis Function

SURFCOM 3000A-3DF



SURFCOM 3000A-3DF-DX

Parallel Processing Dramatically Enhances Efficiency

The ability to perform analysis/printout during the measurement operation dramatically enhances the efficiency of work by eliminating waiting time. The system is also very economical.

Detailed Analysis of 3D Profiles

The adoption of a workstation provides a high-speed processing capability with a maximum of 32,000 points (X) and 2,000 scan lines (Y). A variety of sampling data ensures exact evaluation of sophisticated surface profiles.

Host of 3D Analysis Software

It is difficult to evaluate steel plates, painted surfaces, film, glass and other irregular surfaces with two-dimensional roughness. The 3000A-3DF enables three-dimensional profile, contour line, peak height distribution and other types of evaluation, as well as evaluation of the load curves, area and volume of corrosion and wear on machine parts. Power spectrum evaluation of rotating parts enables analysis of vibration and noise.

Enables Reverse Engineering

• The surface can be generated from the point group data and transferred to a CAD computer, and free curve analysis can be performed (optional program required).

Enhanced Visualization



Shark skin (tilt angle density display)



Surface Texture · Contour Measuring Instruments



Film surface (3D display)



Painted surface (3D display)





Step profile (3D display)



Printed circuit board (3D display)



Specifications	1	
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Model		SURFCOM 3000A-3DF
Measuring area		200 (X) × 100 (Y) mm
Table feed pitch (Y)		0.001 – 100 mm
No. of table feed op	erations (Y)	2 – 2000 times
Straightness	Y axis (front/rear)	(0.05 + 3.0L / 1000) μm
	X axis (horizontal)	(0.05 + 1.5L / 1000) μm
Measuring area		100 × 200 mm
Max. load		10 kg
Recording method		Select color printer or laser printer
Analysis items	Parameters	Center plane average value, square average line, max. height, average value of 10 points, center plane peak height/valley depth, peak count, surface roughness ratio (volume ratio), skewness, kurtosis
	Evaluation curves	Roughness curve, section profile curve, waviness curves (filtered waviness curve, filtered center line waviness curve, rolling circle waviness curve)
	3D analysis display	3D profile display [Airview (hidden line processing, mesh display, height color coding, view-point direction specification)], contour line display, contour line paint-out display, section profile display, peak distribution display, peak height distribution display, load curve display, amplitude distribution (ADF) display, power spectrum *
Auxiliary analysis	Parallel processing	Enables simultaneous execution of measurement, analysis and printout
functions	Printing	Color printing capability (256 colors)
	Enlarged display	Enlarged display of profile, parameter recalculation within specified range
Other analysis		Tilt correction function, tilt angle calculation (tilt curve) function *, polarity reversal function, shading (256 tones) profile display *
Power source		Single phase AC 100 V \pm 10%, 50/60 Hz
Power consumption	1	450 VA
Installation dimensi	ons	2100 (W) \times 900 (D) \times 1650 (H) mm
Weight		370 kg





Advanced Functions and Superior Operational Ease

SURFCOM 2800E SURFCOM 2800E-3DF



TIMS Integrated Measuring System (Roughness/Contour)

Simply touch the icon to change between the roughness and contour measuring modes. Measured data can be combined when printed.

AI Function (Roughness) (patented)

The AI function automatically sets the measuring conditions and executes measurement.

Automatic Operation Log/Playback Function (Roughness/Contour)

This function automatically stores measurement and analysis procedures in the memory, including drive unit and column movements. This enables CNC measurements to be performed.

Dimension Line Display Function (Contour)

• This enables dimension lines to be drawn on the diagram along with actual measured values for parameters and geometric deviation.

Profile Synthesis Function

- The profile synthesis function eliminates the analysis range limitation created by the stylus angle (contour).
 - XACCRETECH TOKYO SEIMITSU

SURFCOM 2800E-3DF * Printer is optional.



With normal measuring systems, limits are imposed on the measuring angle by the detector stylus angle. ACCRETECH has solved this problem by synthesizing the data for two profiles.

Specifications	1					
Model		SURFCOM 2800E				
		Surface Texture Evaluation	Contour Evaluation			
Measuring range	Z axis (vertical)	800 <i>µ</i> m	50 mm			
X axis (horizontal)		100 mm (200 mm with –22 system)	100 mm (200 mm with –22 system)			
Accuracy	Z axis indication accuracy (vertical)	-	\pm (0.8 + 4H / 100) μm (H: Measuring height [mm])			
	Resolution	-	0.025 μm			
	X axis indication accuracy (horizontal)	-	\pm (1 + 2L / 100) μ m (L: Measuring length [mm])			
	Resolution	-	0.1 <i>µ</i> m			
Straightness accura	су	(0.05 + 1.5L / 1000) μ m (L: Measuring length [mm])	1 μ m / 100 mm			
Sensing method	Z axis (vertical)	Differential transducer	Laser beam diffraction scale			
	X axis (horizontal)	Moiré striped scale	Moiré striped scale			
Processing functions Parameters / calculation processing Complies with JIS, Ra, Rq, Ry, Rp Rz.J, R3z, Sm, Status,		Complies with JIS, ISO, DIN, ASME & CNOMO Ra, Rq, Ry, Rp, Rv, Rc, Rz, Rmax, Rt, Rz.J, R3z, Sm, S, R∆a, R∆q, Rλa, Rλq, TILT A, Ir, Pc, Rsk, Rku, Rk, Rpk, Rvk, Mr1, Mr2, VO, K, tp, Rmr, tp2, Rmr2, Rδc, Hmax, Hmin, AREA, NCRX, R, Rx, AR, NR, CPM, SR, SAR Section profile curve, roughness curve, filtered waviness curve, filtered center line waviness curve, rolling circle enatine waviness curve, rolling circle center line waviness curve, filtered waviness curve, roughness motif curve, waviness motif curve, envelope waviness curve Surface characteristic graph, load curve graph, power graph, amplitude distribution (ADF) graph	Point, line, circle, partial circle, ellipse, max. point/min. point, distance, coordinate difference, polar coordinate difference, orthogonal/polar coordinate difference display, intersecting elements (point-line, line- line, circle-line, circle-circle, line-ellipse), symmetric elements (point- point, point-circle, point-ellipse, line-line, circle-circle, circle-ellipse, ellipse-ellipse), coordinate control (zero point setting, X axis setting, parallel movement, rotary movement), surface calculation, over-pin calculation, dimension line display function, calculation result/design value collation, mirror reversal, profile synthesis function, macro function, automatic element discrimination, calculation point repeat function, workpiece trace function, peak and valley function, auto operation log/playback function, profile design value collation, best fit, design value generation, IGES/DXF conversion Zero point setting, X axis setting, parallel movement, rotary movement			
	standard setting	Itrst hair correction, latter hair correction, both end correction, spline curve correction [linear, round surface and both end correction possible at arbitrary range) Set desired uslue or curvespreiging 0.1 1.2 5 10.0 50 100				
Recording	magnification	200 500 1K 2K 5K 10K 20K 50K 100K 200K* 500K*	0.01 - 10,000,000 (arbitray or automatic)			
	Horizontal magnification	Set desired value or automatic: 1, 2, 5, 10, 50, 100, 200, 500, 1K, 2K, 5K, 10K, 20K				
Type of filter		Standard filter (2RC), phase compensation filter (2RC), phase compensation filter (Gaussian)	-			
Cut-off value		Set: 0.025, 0.08, 0.25, 0.8, 2.5, 8, 25 mm (7 stages)	-			
Speed	Column up/down (Z axis)	3 m	m/s			
	Measuring (X axis)	0.03, 0.06, 0.15, 0.3	3, 0.6, 1.5, 3, 6 mm/s			
Sensor unit	Stylus	Replaceable	Replaceable			
	Measuring force	0.7 mN	30 mN or less			
	Stylus radius	2 µm R	25 μm R			
	Stylus material	Diamond	Carbide alloy			
Power source		Single phase AC 10	0 V ±10%, 50/60 Hz			
Power consumption	1	380	VA			
Installation dimensi	ons	1850 (W) × 800 (D) × 750 (H) mm			
Weight		150 kg				



Adopted the latest "Linear Motor" technology Realization of high speed, low vibration and highly accurate measurement



Next Generation Drive Unit with Linear Motor (patent pending)

The world's highest level of measuring speed and lowest vibration enable consistent high-magnification measurements to be performed. The non-contact drive and simple structure (no feed screw or gear box) of the linear motor ensures stable vibration-free operation over an extended period.

High Speed Measurements Dramatically Boost Productivity

Surprisingly high speeds have been achieved: Max. 3 mm/s for roughness measurement, Max. 20 mm/s for waviness measurement and movement speed of 60 mm/s.

The teaching/playback function automates the series of processes, from measurement to pasting of data to generate the inspection report, boosting measuring efficiency by five to ten times (compared to other ACCRETECH model).

Space Saving

 A new design creates a fresh image, and the footprint has been reduced by approximately 25% (compared to previous model). This helps reduce expenses when installing the unit in a constant-temperature room.

Newly Developed High-Performance Compact Detector (Roughness)

• A newly developed detector with a compact design that can perform a wide range of high-magnification measurements has been incorporated. This has provided a measuring range of 1000 μ m with an outer diameter of 14mm, and measuring magnification of 500,000 times.

Higher Precision Enables Measurement of Difficult Workpieces (Contour)

 A measuring accuracy of 2.5 μm (Measuring range: 5mm) that is adequate for measuring molds and other precision parts has been achieved.

This dramatic increase in measuring precision enables measurement of workpieces that required a higher-end model in the past, substantially increasing the range of applications.

Easy Evaluation of Contour of General-Purpose Parts (Contour)

• Accurate data can be obtained quickly for the contour of parts that were evaluated with a projector or tool microscope in the past. The measuring results can be used as is on the inspection report.

Superior ACCRETECH Functions (Roughness/Contour)

Automatic Element Discrimination Function (AI Function) The element (point, line, circle) is automatically determined without being specified by the operator.

Dimension Line Display Function

This enables dimension lines to be drawn on the diagram along with actual measured values for parameters and geometric deviation.

Automatic Crowning Function

The maximum or minimum workpiece values are automatically detected. Calculation Point Repeat Function

Overall analysis of workpieces with profiles that are repeated can be executed by analyzing only one pattern.

Workpiece Trace Function

The measuring range can be determined without setting the values by manually tracing the workpiece once.

This function is ideal for measurement of intricate shapes.

Import/Export Function

Image data can be pasted in the measured results, and measurement waveform data can be pasted in standard programs.





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Roughness analysis function

Contour analysis function

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		SURECOM 1900DX				
Model						
	7 and (contract)	Surface Texture Evaluation	Contour Evaluation			
Measuring range	Z axis (vertical)	1000 µm	50 mm			
Z axis indication accuracy		100 mm	100 mm			
Accuracy (vertical)		-	±(2.5+12HI/100)μm/5mm range, 20mm range, ±(3.5+1 4H I/100)μm/5mm range, H: Measuring height (mm)			
	Resolution	-	0.1μ m/±5mm range, 0.4 μ m/20mm range, 1 μ m/50mm range			
	(horizontal)	-	\pm (1 + 2L / 100) μ m, L: Measuring length (mm)			
	Resolution	_	0.04 <i>µ</i> m			
Straightness accura	icy	(0.05 + 1.0L / 1000) µm, L: Measuring length (mm)	1 μm / 100 mm			
Sensing method	Z axis (vertical)	Differential inductance	Differential transformer			
	X axis (horizontal)	Moiré striped scale	Moiré striped scale			
Processing	Parameters /	Complies with JIS-2001, JIS-1994, JIS-1982, ISO, DIN,	Point, line, circle, partial circle, ellipse, max. point/min. point, distance,			
functions	calculation	ASME & CNOMO	coordinate difference, polar coordinate difference, orthogonal/polar coordinate			
	processing	Ra, Rq, Ry, Rp, Rv, Rc, Rz, Rmax, Rt, Rz.J, R3z, Sm, S,	circle-circle line-ellipse) symmetric elements (point-nine, nine-nine, circle-			
		RΔa, RΔq, R λ a, R λ q,TIL TA, Ir, Pc, Rsk, Rku, Rk,	point-ellipse, line-line, circle-circle, circle-ellipse, ellipse- ellipse),			
		Rpk, Rvk, Mr1, Mr2, VO, K, tp, Rmr, tp2, Rmr2,	coordinate control (zero point setting, X axis setting, parallel movement,			
		R δ c, AVH,Hmax, Hmin, AREA, NCRX, R, Rx, AR, NR,	rotary movement), surface calculation, over-pin calculation,			
		CPM, SR, SAR	dimension line display function, calculation result/design value collation,			
			discrimination, calculation point repeat function, workpiece trace function.			
			peak and valley function, auto operation log/playback function			
	Evaluation curves	Section profile curve, roughness curve, filtered waviness curve,				
		filtered center line waviness curve, rolling circle waviness curve,	-			
		roughness motif curve, waviness motif curve, envelope waviness curve				
	Surface characteristic graph	Load curve graph, power graph, amplitude distribution (ADF) graph	_			
Tilt correction		Linear correction, round surface correction, first half correction,				
		(linear, round surface and both end correction, spline curve correction (linear, round surface and both end correction possible at arbitrary range)	_			
Recording	Vertical magnification	50, 100, 200, 500, 1K, 2K, 5K, 10K, 20K,	0.01 - 10,000,000 (Possible for any or automatic value)			
		50K, 100K, 200K, 500K, arbitrary, auto	0.01 - 10,000,000 (Possible for any or automatic value)			
	Horizontal magnification	0.1, 1, 2, 5, 10, 50, 100, 200, 500, 1K, 2K, 5K, 10K, 20K, arbitrary, auto	-			
Type of filter		Standard filter (2RC), phase compensation filter (2RC),	_			
		phase compensation filter (Gaussian)				
Cut-off value		Set: 0.025, 0.08, 0.25, 0.8, 2.5, 8, 25 mm (7 stages)	-			
Speed	Column up/down (Z axis)	3 - 10) mm/s			
Measuring (X		0.03 - 2	20 mm/s			
Sensor unit	Stylus	Replaceable	Replaceable			
	Measuring force	0.7 mN	30 mN or less			
	Stylus radius	2 <i>µ</i> m R	25 <i>µ</i> m R			
	Stylus material	Diamond	Carbide alloy			
Measuring feed direction		-	Push/pull, both directions			
Measuring orientati	on	-	Up/down, both directions			
Power source		Single phase AC 10	00 V ±10%, 50/60 Hz			
Power consumption	1	400) VA			
Installation dimensi	ons	1250 (W) × 850 (D) × 1500 (H) mm			
Weight		Approx. 125 kg				





Advanced Functions and Superior Operational Ease

SURFCOM 1800D SURFCOM 1800D-3DF





SURFCOM 1800D-3DF

* Printer is optional.

[TIMS] Integrated Measuring System (Roughness/Contour)

• Simply touch the icon to change between the roughness and contour measuring modes. Measured data can be combined when printed.

AI Function (Roughness) (patented)

• The AI function automatically sets the measuring conditions and executes measurement.

Automatic Operation Log/Playback Function (Roughness/Contour)

This function automatically stores measurement and analysis procedures in the memory, including drive unit and column movements. This enables CNC measurements to be performed.

Automatic Element Discrimination Function [AI Function] (Contour)

The element (point, line, circle) is automatically determined without being specified.

Dimension Line Display Function (Contour)

 This enables dimension lines to be drawn on the diagram along with actual measured values for parameters and geometric deviation.

Profile Synthesis Function

• The profile synthesis function eliminates the analysis range limitation created by the stylus angle.





Specifications						
Model		SURFCOM 1800D				
		Surface Texture Evaluation	Contour Evaluation			
Measuring range	Z axis (vertical)	800 µm	50 mm			
	X axis (horizontal)	100 mm (200 mm with –22 system)	100 mm (200 mm with –22 system)			
Accuracy Z axis indication accuracy (vertical) Resolution		_	$\pm0.25\%$ full scale (±4 μm or less for 5 mm range)			
		-	0.1μ m/±2.5mm, 0.4μ m/±10mm, 1μ m/±25mm,			
	X axis indication accuracy (horizontal)	-	\pm (1 + 2L / 100) μm L: Measuring length [mm]			
	Resolution	-	0.1 <i>µ</i> m			
Straightness accura	су	(0.05 + 1.5L / 1000) µm (L: Measuring length [mm])	1 µm / 100 mm			
Sensing method	Z axis (vertical)	Differential transformer ducer	Differential transformer ducer			
	X axis (horizontal)	Moiré striped scale	Moiré striped scale			
Processing functions	ctionsParameters / calculation processingComplies with JIS-2001, JIS-1994, JIS-1982, ISO, DIN, ASME & CNOMOPoint, line, circle, partial circle distance, coordinate difference orthogonal/polar coordinate or elements (point-line, line-line, circle-circle, 		Point, line, circle, partial circle, ellipse, max. point/min. point, distance, coordinate difference, polar coordinate difference, orthogonal/polar coordinate difference display, intersecting elements (point-line, line-line, circle-line, circle-circle, line- ellipse), symmetric elements (point-point, point-circle, point- ellipse, line-line, circle-circle, circle-ellipse, ellipse-ellipse), coordinate control (zero point setting, X axis setting, parallel movement, rotary movement), surface calculation, over-pin calculation, dimension line display function, calculation result/design value collation, mirror reversal, profile synthesis function, macro function, automatic element discrimination, calculation point repeat function, workpiece trace function, peak and valley function, auto operation log/playback function			
	Evaluation curves	Section profile curve, roughness curve, initered waviness curve, filtered center line waviness curve, rolling circle waviness curve, rolling circle center line waviness curve, DIN4776 special curve, roughness motif curve, waviness motif curve, envelope waviness curve	-			
	graph	Load curve graph, power graph, amplitude distribution (ADF) graph	-			
	Tilt correction	first half correction, latter half correction, both end correction, spline curve correction (linear, round surface and both end correction possible at arbitrary range)				
Recording Vertical magnification		50, 100, 200, 500, 1K, 2K, 5K, 10K, 20K,	0.01 - 10,000,000 (Possible for any or automatic value)			
		50K, 100K, 200K*, 500K*, arbitrary, auto	0.01 - 10,000,000 (Possible for any or automatic value)			
	Horizontal magnification	1, 2, 5, 10, 50, 100, 200, 500, 1K, 2K, 5K, 10K, 20K, arbitrary, auto	-			
Type of filter		Standard filter (2RC), phase compensation filter (2RC),				
		phase compensation filter (Gaussian)	_			
Cut-off value		Set: 0.025, 0.08, 0.25, 0.8, 2.5, 8, 25 mm (7 stages)	-			
Speed Column up/down (Z axis)		3 mm/s				
	Measuring (X axis)	0.03, 0.06, 0.15, 0.3, 0.6,	1.5, 3, 6 mm/s (8 speeds)			
Sensor unit	Stylus	Replaceable	Replaceable			
	Measuring force	0.7 mN	30 mN or less			
	Stylus radius	2 µm R	25 µm R			
Stylus material		Diamond	Carbide alloy			
Measuring feed dire	ction	-	Push/pull, both directions			
Measuring orientation	on	-	Up/down, both directions			
Power source		Single phase AC 10	0 V ±10%, 50/60 Hz			
Power consumption	1	380	VA			
Installation dimensi	ons	1850 (W) × 800 (D) × 750 (H) mm			
Weight		150) kg			

* When high-magnification pickup is used.

ZACCRETECH TOKYO SEIMITSU

Quick Response!

Linear Motor Achieves High-Speed, Low-Vibration Roughness Measurements

SURFCOM 1500DX

SURFCOM 1500DX-3DF





World's First Linear Motor in a Roughness Instrument (patent pending)

The world's highest level of measuring speed and lowest vibration enable consistent highmagnification measurements to be performed.

The non-contact drive and simple structure (no feed screw or gear box) of the linear motor ensures stable vibration-free operation over an extended period.

High Speed Measurements Dramatically Boost Productivity

Extremely high speeds have been achieved: Max. 3 mm/s for roughness measurement, Max. 20 mm/s for waviness measurement and movement speed of 60 mm/s (compared to other ACCRETECH model).

Newly Developed High-Performance Compact Detector

A newly developed detector with a compact design that can perform a wide range of highmagnification measurements has been incorporated.

This has provided a measuring range of $1000\,\mu\,m$ with an outer diameter of 14mm, and measuring magnification of 500,000 times.

Space Saving

A new design creates a fresh image, and the footprint has been reduced by approximately 25% (compared to previous model).

This helps reduce expenses when installing the unit in a constant-temperature room.



Glass flatness measurement

Measuring range	20mm × 20mm
	1000 lines (Y direction)
Conventional machine	165 minutes
S1500DX-3DF	22 minutes

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Surface Texture · Contour Measuring Instruments

AI Function Simplifies Measurements (patented)

The unit automatically selects the measuring conditions without setting them in advance (roughness measurement). In addition, a lesson mode is available to teach the user the operation procedures. This is a reflection of ACCRETECH's commitment to create measuring instruments that anyone can use.

Automation Enhances Measurement Efficiency

- The teaching function can be used to automate a series of operations, from measurement at multiple locations to generation of an inspection report by pasting the data.
- Moving speed of 60mm/s has been realized, which enables drastic increase of measuring efficiency in sequent measurement of whole surfaces.



Evaluation Functions Dramatically Strengthened

• A variety of customer requests for more evaluation functions have been reflected in the 1400D. These include accommodation of standards for film thickness measurement (step/area), wear volume calculation (superimposed profile area) and LCD glass substrate (special waviness).

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TIMS Flexible Measuring System

• The TIMS next-generation integrated measuring system is a new breakthrough from ACCRETECH. It links different programs with a single icon, enhancing the ease of analysis.

Complies with World Standards

• The 1400D complies with the latest ISO, JIS, DIN, ASME, CNOMO and other standards, and has satisfied the European Directives for the CE Marking. It can be used with English, Japanese, German, French and Italian (please consult with ACCRETECH when taking it to a different country).

Reanalysis After One Measurement

Data can be reanalyzed after one measurement is performed. The measurement standard (linear, first half, latter half, round surface, both end) can be changed to set the measuring range for analysis, or the defective data for a notch can be removed.

Outstanding Expandability

• The unit can be easily and efficiently upgraded to meet evolving needs. This includes upgrading from two-dimensional to three-dimensional roughness, or adding profile capability.

Flexible input and output function

Import and export function enables to paste picture data into measured result and to paste measured wave form data into a program on the market.

Two-Dimensional Roughness				
Model		SURFCOM 1500DX		
Measuring range / X axis (horizontal)		100mm/0.04µm or 32,000 points (max. data items) (300,000 data uptake points)		
Resolution	Z axis (vertical)	1000µm/0.02µm – 6.4µm/0.0001µm		
Straightness		(0.05 + 1.0L / 1,000) μ m L = Measuring length (mm)		
Analysis items	Standards	Complies with JIS-2001, JIS-1994, JIS-1982, ISO-1997, ISO-1984, DIN-1990, ASME-1995 and CNOMO.		
	Parameters	Ra, Rq, Ry, Rp, Rv, Rc, Rz, Rmax, Rt, Rz.J, R3z, Sm, S, R Δ a, R Δ q, R λ a, R λ q		
		TILT A, Ir, Pc, Rsk, Rku, Rk, Rpk, Rvk, Mr1, Mr2, VO, K, tp, Rmr, tp2, Rmr2, R δ c		
		AVH, Hmax, Hmin, AREA, NCRX, R, Rx, AR, NR, CPM, SR, SAR		
	Evaluation curves	Section profile curve, roughness curve, filtered waviness curve, filtered center line waviness curve, rolling circle waviness curve,		
		rolling circle center line waviness curve, DIN4776 special curve, roughness motif curve, waviness motif curve, envelope waviness curve		
Special graphs Tilt correction		Load curve, amplitude distribution (ADF) curve, power graph		
		Linear correction, round surface correction, first half correction, latter half correction, both end correction, spline curve correction (linear, round surface and both end correction possible at arbitrary range)		
Magnification Vertical magnification (Z axis)		Set desired value or automatic: 50, 100, 200, 500, 1K, 2K, 5K, 10K, 20K, 50K, 100K, 200K, 500K		
	Horizontal magnification (X axis)	Set desired value or automatic: 0.1, 1, 2, 5, 10, 20, 50, 100, 200, 500, 1K, 2K, 5K, 10K, 20K		
Type of filter		Standard filter (2RC), phase compensation filter (2RC), phase compensation filter (Gaussian)		
Measuring speed		(Roughness) 0.03 - 3 mm/s (Waviness) 0.03 - 20 mm/s		
Moving speed		(Z axis) - 10 mm/s (X axis) - 60 mm/s		
Detector		Tip radius: 2μ m, Material: Diamond, Measuring force: 0.7 mN		
Special functions	Measuring AI	Al function provides easy procedures, enabling beginners to make measurements.		
	Waveform superimposition	Waveform curve for a maximum of 10 data items can be superimposed (ideal for wear evaluation).		
	Automatic operation	Simplified auto mode and teaching mode enable fully automatic operation.		

Power source/consumption	AC 100 V ±10%, 50/60 Hz, 300 VA		
Installation dimensions	1250 (W) × 850 (D) × 1500 (H) mm		
Weight	Approx. 125 kg		

🔀 ACCRETECH TOKYO SEIMITSU



Superior Operating Ease & Automation of Measurements to Inspection Reports

SURFCOM 1400D



AI Function Simplifies Measurements (patented)

The unit automatically selects the measuring conditions without setting them in advance (roughness measurement). In addition, a lesson mode is available to teach the user the operation procedures. This is a reflection of ACCRETECH's commitment to create measuring instruments that anyone can use.

Automation Enhances Measurement Efficiency

 The teaching function can be used to automate a series of operations, from measurement at multiple locations to generation of an inspection report by pasting the data.



TIMS Flexible Measuring System

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Complies with World Standards

The 1400D complies with the latest ISO, JIS, DIN, ASME, CNOMO and other standards, and has satisfied the European Directives for the CE Marking. It can be used with English, Japanese, German, French and Italian (please consult with ACCRETECH when taking it to a different country).

Reanalysis After One Measurement

 Data can be reanalyzed after one measurement is performed. The measurement standard (linear, first half, latter half, round surface, both end) can be changed to set the measuring range for analysis, or the defective data for a notch can be removed.

Outstanding Expandability

 The unit can be easily and efficiently upgraded to meet evolving needs. This includes upgrading from two-dimensional to three-dimensional roughness, or adding profile capability.

Evaluation Functions Dramatically Strengthened

 A variety of customer requests for more evaluation functions have been reflected in the 1400D. These include accommodation of standards for film thickness measurement (step/area), wear volume calculation (superimposed profile area) and LCD glass substrate (special waviness).



Surface Texture · Contour Measuring Instruments

Measurement

- Easy operation with icons and pull-down menus. Icons can be edited according to individual preferences.
- Real-time display of data.
- Unit can be controlled using manual mode, joystick or mouse.



Measuring screen

Analysis

- Desired measuring standard and evaluation range can be set.
- Evaluation according to different standards can be performed by simply recalculating the data.



Superimposition Function

Differences before and after machining can be determined by superimposing data on the screen and calculating the different area figures for both sets of data. Up to 10 data items on the screen can be stored, and evaluation can be performed by superimposing the data sets.



Printing

• The measured results can be formatted according to individual requirements and printed as an inspection report.



Specifications Two-Dimensional Roughness

Two-Dimensional	nougimess	
Model		SURFCOM 1400D
Measuring range /	X axis (horizontal)	100mm/0.1µm or 32,000 points (max. data items)
Resolution	Z axis (vertical)	800μm/0.02μm – 25μm/0.0004μm (6.4μm/0.0001μm*)
Straightness		$(0.05 + 1.5L / 1,000) \ \mu m \ L = Measuring length (mm)$
Analysis items	Standards	Complies with JIS-2001, JIS-1994, JIS-1982, ISO-1997, ISO-1984, DIN-1990, ASME-1995 and CNOMO.
	Parameters	Ra, Rq, Ry, Rp, Rv, Rc, Rz, Rmax, Rt, Rz.J, R3z, Sm, S, R Δ a, R Δ q, R λ a, R λ q
		TILT A, Ir, Pc, Rsk, Rku, Rk, Rpk, Rvk, Mr1, Mr2, VO, K, tp, Rmr, tp2, Rmr2, R δ c
		AVH, Hmax, Hmin, AREA, NCRX, R, Rx, AR, NR, CPM, SR, SAR
	Evaluation curves	Section profile curve, roughness curve, filtered waviness curve, filtered center line waviness curve, rolling circle waviness curve,
		rolling circle center line waviness curve, DIN4776 special curve, roughness motif curve, waviness motif curve, envelope waviness curve
	Special graphs	Load curve, amplitude distribution (ADF) curve, power graph
	Tilt correction	Linear correction, round surface correction, first half correction, latter half correction, both end correction, spline curve correction (linear, round surface and both end correction possible at arbitrary range)
Magnification (Z axis) Horizontal magnification (X axis)		Set desired value or automatic: 50, 100, 200, 500, 1K, 2K, 5K, 10K, 20K, 50K, 100K, 200K*, 500K*
		Set desired value or automatic: 0.1, 1, 2, 5, 10, 20, 50, 100, 200, 500, 1K, 2K, 5K, 10K, 20K
Type of filter		Standard filter (2RC), phase compensation filter (2RC), phase compensation filter (Gaussian)
Measuring speed		0.03, 0.06, 0.15, 0.3, 0.6, 1.5, 3, 6 mm/s
Detector		Tip radius: 2μ m, Material: Diamond, Measuring force: 0.7 mN
Special functions	Measuring Al	Al function provides easy procedures, enabling beginners to make measurements.
	Waveform superimposition	Waveform curve for a maximum of 10 data items can be superimposed (ideal for wear evaluation).
	Automatic operation	Simplified auto mode and teaching mode enable fully automatic operation.
Other Specificatio	ns	
Power source/cons	umption	AC 100 V ±10%, 50/60 Hz, 300 VA
Installation dimensi	ons	1700 (W) × 500 (D) × 750 (H) mm
Weight		Approx. 125 kg (2D model), Approx. 135 kg (3D model)





Versatile Analysis of Minute Surface Characteristics

SURFCOM 1400D-3DF



Parallel Processing Dramatically Enhances Efficiency

The ability to perform analysis/printout during the measurement operation dramatically enhances the efficiency of work by eliminating waiting time. The system is also very economical.

Detailed Analysis of 3D Profiles

The system has a high-speed processing capability with a maximum of 32,000 points (X) and 2,000 scan lines (Y). A variety of sampling data ensures exact evaluation of sophisticated surface profiles.

Host of 3D Analysis Software

 It is difficult to evaluate steel plates, painted surfaces, film, glass and other irregular surfaces with two-dimensional roughness. The 1400D-3DF enables three-dimensional profile, contour line, peak height distribution and other types of evaluation, as well as evaluation of the load curves, area and volume of corrosion and wear on machine parts.
 Power spectrum evaluation of rotating parts enables analysis of vibration and noise.

Specifications		
Two-Dimensional	Roughness	
Model		SURFCOM 1400D-3DF
Fixed pitch drive unit Measuring range (Y axis)		50 mm
	Feed pitch	0.001 – 10 mm
	Feed cycles	2 – 2,000 times
	Straightness accuracy	(0.05 + 3.0L / 1,000) μ m L = Measuring length (mm)
	Max. load	5 kg
Analysis items	3D roughness	SRa, SRq, SRmax, SRz, SRp, SRv, SPc, SSI, SRsk, SRsku, SMr1, SRMr2
parameters		SRpk, SRvk, SRk, SVO, SK
Display analysis		3D display, contour line display, contour line paint-out display, contour line intensity display, section profile display, peak distribution display, Airview (hidden line
function		processing, mesh display, view-point direction specification), load curve display, amplitude distribution (ADF) curve display, peak height distribution display
3D tilt correction		Plane correction (all data, display range, point specification, specified range [rectangular, circular, polygonal]),
		spherical surface correction*, cylindrical surface correction*, parabolic correction*
Special functions	Parallel processing	Enables simultaneous measurement, analysis and printing, and boosts throughput.
	Total measuring system	Provides effective links between 2D and 3D analysis, enabling generation of integrated inspection reports.
Expandability (optional program set)		Shading*, peak height average value*, average tilt angle calculation*, power spectrum* (multi-section), section profile area distribution*, tilt angle intensity
Other Specificatio	ns	
Power source/const	umption	AC 100 V ±10%, 50/60 Hz, 300 VA
Installation dimensi	ons	1700 (W) × 500 (D) × 750 (H) mm
Wainht		

*: Indicates optional functions. NOTE: Accuracy guarantee for 3D roughness is up to 10K

Surface Texture · Contour Measuring Instruments

Standard Functions





Gray display



Load curve



Contour line display



Cut surface display



Amplitude distribution curve



Contour line paint-out display



Airview



Peak height distribution

Options



Shading display



Peak height average value calculation



Multi-section power spectrum



Average tilt angle calculation



Tilt angle density display



Cut surface area distribution



LCD Glass Substrate Waviness Measuring Instrument

SURFCOM 1400D-LCD

- Wide measuring range to effectively meet user needs: 300 × 250, □500, □650, □900, □1300mm.
- Capable of measuring swell, roughness, bowing, step profile and other characteristics.
- Uses SURFCOM 1400D computer for data processing unit.



Mea	asuring range: ⊡650mm type

Specifications

Model	SURFCOM 1400D-LCD
Vertical measuring magnification	Set desired value or automatic: 50 - 500 K *
Horizontal measuring magnification	1 – 20 K
Measuring force:	Set desired value or automatic: 50 – 500 K *
Straightness accuracy	Set desired value or automatic: 1 - 20
L: Measuring length (mm)	4 mN or less
	Measuring range: 300, 600 & 650 types
	(0.05 + 1.5L / 1000) µm
	Measuring range: 900 type
	(0.1 + 1.5L / 1000) µm
Parameters	Measuring range: 1300 type
	(0.2 + 1.5L / 1000) μm
	Roughness: 36 types, Waviness: 24 types

* When high-magnification pickup is used.

Color PDP Profile Measuring Instrument



- Dedicated instrument for optimal measurement of film deposition thickness on color PDP front substrates and rib height on back substrates.
- Motor driven X/Y Motor driven tracing driver itself (Range: 900 mm in X direction and 1300 mm in Y direction). Measurements can be performed within this movement range.
- Uses SURFCOM 1400D computer for data processing unit.





Data processing unit

opeometations	
Model	SURFCOM 1400D-PDP
X-Y movement range	X= 900mm (motor driven), Y=1300mm (motor driven)
X-Y movement speed	Max. 100 mm/sec.
Measuring height	50 mm: Z axis stroke (manual)
Drive unit tilt angle	±5° (manual)
Roughness measuring range	100mm: X axis direction
Straightness accuracy	(0.05 + 1.5L / 1000) μ m L: Measuring length (mm)
Vertical recording magnification	Set desired value or automatic: 50-50K *
Horizontal recording magnification	Set desired value or automatic: 1-20K *
Measuring force	0.7 mN
Load	20 kg or less
Power source	AC 100 V ±10%, 50/60 Hz
External dimensions	2040 (W) \times 1420 (D) \times 1350 (H) mm (excluding CPU)
Weight	Approx. 1800 kg

* When high-magnification pickup is used

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Surface Texture · Contour Measuring Instruments



Applications

Wafer Profile Measurement
 CCD camera enables exact positioning.



Sample configuration with SURFCOM 1400D and CCD camera

Hard Disk Measurement

Dedicated software available for SURFCOM 480A.



Measurement of hard disk using SURFCOM 480A

Non-Contact Measurement

The use of an optical pickup allows measurement of plastic, film, paper and other soft materials.



E-DT-SL-12B optical pickup



Field Surface Texture Measuring Instrument with Outstanding Operating Ease



TFT Color LCD Touch Panel

Customize Icons

operational efficiency.

AI Function (patented)

ing. This automates measurement.

The color LCD touch panel with a wide field of view features high clarity. Simply touch the desired icon to perform operation. Touch panel input can be performed by using your finger or with the touch-pen provided, facilitating on-site measurements.

The customize function can be used to create a spe-

cial menu where only the icons that are used most

The AI (artificial intelligence) function automatically

selects the ideal cut-off value, measuring range and

other conditions by simply entering the parameters

and allowable values denoted on the machining draw-

This function guides the user through the measuring

procedures, enabling beginners to make measure-

frequently are displayed, substantially enhancing

Supports International Standards

The 480A supports analysis parameters for JIS (2001/1994/1982), ISO, DIN, ASME and CNOMO standards, and can be switched between English, Japanese, German, Italian, French and Spanish. In addition, any power source between AC100V and 240V can be used, and the unit satisfies the European Directives for the CE Marking.



Host of Analysis Functions

The unit incorporates 34 types of roughness parameters (Ra, Rz, Ry, Sm, S, tp, etc.) and 32 types of waviness parameters. The steps on electrical parts, film thickness, surface area and other items can be analyzed.



Tilt Correction Function

Six types of automatic tilt correction are provided: Linear, first half, latter half, both end, round surface and spline curve (patented).



Evaluation Range Setting (patented)

The waveform on the screen is enclosed by two cursors, allowing the desired evaluation range to be set and the parameters to be calculated.

PC Card Slot



Measuring conditions, measured result management or measured data can be output in binary and text format. This data can be easily read from the PC card slot on a personal computer.



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AI

Memo Function

ments.

Guidance Function

A short note or diagram can be entered with the touch pen and printed using the memo function.



Sample Display

The customize function on the main menu allows icons to be edited and arranged as desired.



Analysis Results (E.Length 10.44 % C2= 10.44 % BAC(P) 19.763 µm 0.00 %) P-P X 19.10 .10 % 19.10 0.00 C1-C2= X ADF(P) P-P = 19.763 μm 1 = 0.00 % (E.Length 0.09 % C2= 0.10 1.815 *µ*m P-P = wer Graph 1.229 mm 15.554 *µ*m 1.815 μm 0.038 μm Zoom Whole Curs ▼ Cursor 1: . Cur Cursor 2: Load curve < < Amplitude distribution curve O K -WAA Power graph

Sample Customized Display



Sample Data Sheet



Specifications

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Model		SURFCOM 480A	
Measuring range	X axis (horizontal)	100mm	
	Z axis (vertical)	$800\mu m$ (Measuring range/resolution: $800\mu m/10nm$, $80\mu m/1nm$, $8\mu m/0.1nm$)	
Straightness accura	асу	$(0.05 + 1.5L / 1,000) \mu m L =$ Measuring length (mm)	
Analysis items	Standards	Complies with JIS-2001, JIS-1994, JIS-1982, ISO-1997, ISO-1984, DIN-1990, ASME-1995 and CNOMO.	
	Parameters	Ra, Rq, Ry, Rp, Rv, Rc, Rz, Rmax, Rt, Rz.J, R3z, Sm, S, R Δ a, R Δ q, R λ a, R λ q,	
		TILT A, Ir, Pc, Rsk, Rku, Rk, Rpk, Rvk, Mr1, Mr2, VO, K, tp, Rmr, tp2, Rmr2, Rδc,	
		AVH, Hmax, Hmin, AREA, NCRX, R, Rx, AR, NR, CPM, SR, SAR	
	Evaluation curves	Section profile curve, roughness curve, filtered waviness curve, filtered center line waviness curve, rolling circle waviness curve,	
		rolling circle center line waviness curve, DIN4776 special curve, roughness motif curve, waviness motif curve, envelope waviness curve	
	Special graphs	Load curve, amplitude distribution (ADF) curve, power graph	
	Tilt correction	Linear correction, round surface correction, first half correction, latter half correction, both end correction,	
		spline curve correction (linear, round surface and both end correction possible at arbitrary range)	
Magnification	Vertical magnification (Z axis)	Set desired value or automatic: 50, 100, 200, 500, 1K, 2K, 5K, 10K, 20K, 50K, 100K, 200K*, 500K*	
	Horizontal magnification (X axis)	Set desired value or automatic: 1, 2, 5, 10, 20, 50, 100, 200, 500, 1K, 2K	
Type of filter		Standard filter (2RC), phase compensation filter (2RC), phase compensation filter (Gaussian)	
Measuring speed		0.03, 0.06, 0.15, 0.30, 0.60, 1.5, 3, 6 mm/s (8 speeds)	
Detector		Tip radius: 2µm, Material: Diamond, Measuring force: 0.7 mN	
Special functions	Measuring AI	Al function provides easy procedures, enabling beginners to make measurements.	
	Step analysis function	Ideal for film thickness and surface area measurement of semiconductor parts.	
	PC card	Output as text file allows transfer of data to personal computer.	
Standard accessori	es	Standard specimen (E-MC-S24B), recording paper (E-CH-S21A), touch-pen (E-MA-S54A), instruction manual	
Power source/cons	umption	AC 100 – 240 V ±10%, 50/60 Hz, 90 VA	
Installation dimensi	ions	1000 (W) × 800 (D) × 750 (H) mm	
Weight		105 kg	

* When high-magnification pickup is used.



Compact Field Surface Texture Measuring Instrument with High Operational Ease



SURFCOM 130A

LCD Panel Simplifies Operation

 Simply select the desired operation from the color LCD touch panel with a wide field of view or the reasonable monochrome LCD.

Highly Portable Compact Unit

The unit is small enough for use at virtually any location.

Supports International Standard Analysis Parameters

Select the desired standard: JIS, ISO, DIN, ASME or CNOMO.

Satisfies European Directives for CE Marking









Surface Texture · Contour Measuring Instruments

Customize Icons

The customize function can be used to create a special menu where only the icons that are used most frequently are displayed, substantially enhancing operational efficiency.

AI Function (patented)

The AI (artificial intelligence) function automatically selects the ideal cut-off value, measuring range and other conditions by simply entering the parameters and allowable values denoted on the machining drawing. This automates measurement.



(AI)

Guidance Function

This function guides the user through the measuring procedures, enabling beginners to make measurements.



Memo Function

A short note or diagram can be entered with the touch pen and printed using the memo function.



Host of Analysis Functions

The unit incorporates 34 types of roughness parameters (Ra, Rz, Ry, Sm, S, tp, etc.) and 32 types of waviness parameters. The steps on electrical parts, film thickness, surface area and other items can be analyzed.



Tilt Correction Function

Six types of automatic tilt correction are provided: Linear, first half, latter half, both end, round surface and spline curve (patented).



Evaluation Range Setting (patented)

The waveform on the screen is enclosed by two cursors, allowing the desired evaluation range to be set and the parameters to be calculated.

PC Card Slot

PC-Card

Measuring conditions, measured result management or measured data can be output in binary and text format. This data can be easily read from the PC card slot on a personal computer.





Convenient Mode Select Function for System Manager/Operator

Specifications

Model		SURFCOM 130A
Measuring range	X axis (horizontal)	50mm
	Z axis (vertical)	800μm (Measuring range/resolution: 800μm/10nm, 80μm/1nm, 8μm/0.1nm)
Straightness accura	acy	0.3 μm / 50 mm
Analysis items	Standards	Complies with JIS-2001, JIS-1994, JIS-1982, ISO-1997, ISO-1984, DIN-1990, ASME-1995 and CNOMO.
	Parameters	Ra, Rq, Ry, Rp, Rv, Rc, Rz, Rmax, Rt, Rz.J, R3z, Sm, S, RΔa, RΔq, λa, Rλq,
		TILT A, Ir, Pc, Rsk, Rku, Rk, Rpk, Rvk, Mr1, Mr2, VO, K, tp, Rmr, tp2, Rmr2, Rδc,
		AVH, Hmax, Hmin, AREA, NCRX, R, Rx, AR, NR, CPM, SR, SAR
	Evaluation curves	Section profile curve, roughness curve, filtered waviness curve, filtered center line waviness curve, rolling circle waviness curve,
		rolling circle center line waviness curve, DIN4776 special curve, roughness motif curve, waviness motif curve, envelope waviness curve
	Special graphs	Load curve, amplitude distribution (ADF) curve, power graph
Tilt correction		Linear correction, round surface correction, first half correction, latter half correction, both end correction,
		spline curve correction (linear, round surface and both end correction possible at arbitrary range)
Magnification Vertical magnification (Z axis)		Automatic: 50, 100, 200, 500, 1K, 2K, 5K, 10K, 20K, 50K, 100K
	Horizontal magnification (X axis)	Automatic: 1, 2, 5, 10, 20, 50, 100, 200, 500, 1K, 2K, 5K
Type of filter		Standard filter (2RC), phase compensation filter (2RC), phase compensation filter (Gaussian)
Measuring speed		0.3, 0.6, 1.5, 3 mm/s (4 speeds)
Detector		Tip radius: 2μ m, Material: Diamond, Measuring force: 0.7 mN
Special functions	Measuring Al	Al function provides easy procedures, enabling beginners to make measurements.
	Step analysis function	Ideal for film thickness and surface area measurement of semiconductor parts.
	PC card	Output as text file allows transfer of data to personal computer.
Standard accessori	es	Automatic (E-MC-S24B), recording paper (E-CH-S21A), touch-pen (E-MA-S54A), instruction manual
Power source/const	umption	AC 100 – 240 V ±10%, 50/60 Hz, 30 VA
Installation dimensi	ons	700 (W) × 300 (D) × 150 (H) mm
Weight		8 kg

* PC card (E-MU-S550A) and PC connection cable (E-SC-S288A) are optional.





Extra Compact Unit with Host of Functions





AI Function Achieves Easy Operability

The AI function (patent pending) automatically sets the ideal values for measuring range, evaluation length, cut-off value and recording magnification (when printer is used) according to the surface being measured.

Use Anywhere in the World

The E-35A supports JIS (2001/1994/1982), ISO, DIN, ASME and CNOMO standards, and can be switched between English, Japanese, German, Italian, French, Spanish and Portuguese. In addition, the unit satisfies the European Directives for the CE Marking.



Directly Transfer Data to PC

 The standard RS-232C serial port allows measuring conditions, parameter values and profile curve data to be directly transmitted to a PC.

Data Storage/Rechargeable Battery

• Ten different data items can be stored in the internal memory, and the measured data can be called at any time. Both the HANDYSURF and printer have built-in rechargeable batteries, making them ideal for on-site measurements where a power source is not readily available.

Measurements from Any Orientation

The compact lightweight HANDYSURF unit can be used to make measurements in a horizontal, vertical, tilted or any other orientation. The display and drive units can be used together as a one-piece instrument, or separated for measurement purposes according to individual requirements.

Replaceable Displacement Pickup

The displacement pickup enables exact and faithful measurement of surface roughness. Since it is replaceable, dedicated optional pickups can be used for extra small holes and deep grooves, facilitating a diverse range of measurements.



7-language capability, supports world standards, rechargeable battery, PC compatible Worldwide Compatibility



opecification	5			
Model			HANDYSURF E-35A	
Measuring range	Z axis (vert	tical)	±160 μm	
	X axis (horizontal)		12.5 mm	
Resolution	Z axis (vertical)		0.01 μm / ±20 – 0.08 μm / ±160 μm	
Analysis items	Standards	supported	Complies with JIS-2001, JIS-1994, JIS-1982, ISO-1997, ISO-1984, DIN-1990, ASME-1995 and CNOMO.	
	Parameters	JIS-2001	Pt, Ra, Rq, Rz, Rzmax, Rp, Rt, R3z, RSm, Pc, Rk, Rpk, Rvk, Mr1, Mr2, VO, K, Rmr	
		motif	R, Rx, AR, W, Wx, AW, Wte	
	Evaluation	curves	Section profile curve, roughness curve, ISO 13565 special curve, roughness motif curve, waviness motif curve, envelope waviness curve	
Filter	Cut-off met	thod	Gaussian Filter, 2RC filter	
	Cut-off valu	ue	λc: 0.08, 0.25, 0.8, 2.5 mm λs: 2.5, 8 μm	
Evaluation length	Fixed mode	e	Cut-off value × 5	
	Arbitrary m	node	0.4 – 12.5 mm (Unit: 0.1 mm)	
Drive speed			0.6 mm/s (return speed 1 mm/s)	
Pickup	Sensing m	ethod	Differential inductance (displacement type)	
	Stylus		Diamond, 90° cone, 5 μ m R	
	Measuring	force	4 mN or less	
	Skid		Sapphire, 32 mm R (trace direction)	
Power source			Built-in rechargeable battery (charged with AC adapter)	
Power consump	tion		Approx. 1 VA	
Weight			Approx. 600 g	
External dimens	ions		210 (W) \times 70 (D) \times 60 (H) mm	
Standard accessories			Reference specimen (E-MC-S24B), rear adjustment piece (E-WJ-S64A), extension cable (E-SC-S255A),	
			Handy case (E-MA-S35A), AC adapter, instruction manual	
Printer (option))			
Name			Compact Printer II	
Model			E-RC-S25A	
Printing method			Thermal line dot	
Recording curves			Section profile curve, roughness curve, load curve, roughness motif curve, waviness motif curve, envelope waviness curve	
Recording	Vertical di	rection (V)	×100, ×200, ×500, ×1K, ×2K, ×5K, ×10K, AUTO	
magnification	Horizontal	direction (H)	×1, ×2, ×5, ×10, ×20, ×50, ×100, ×200, AUTO	
Weight			Approx. 390 g	
External dimens	ions		140 (W) \times 100 (D) \times 40 (H) mm	
Accessories			Recording paper: E-CH-S25A, Connection cable: E-SC-S245A	

* Excel is a trademark of Microsoft Corporation.



Surface Texture · Contour Measuring Instruments

Nano Profile Scanner

The NPS2100A has a probe tip diameter that can be measured in the tens of nanometers. Using this probe to scan the workpiece surface enables irregularities to be displayed in three dimensions with nanometer level resolution.

The measuring unit has a self detecting type cantilever and vibration isolation mechanism as standard features. In addition, it is compact enough to be used on a desk and features outstanding operational ease.



Nanometer Level Profile Evaluation

• The NPS2100A performs analysis of minute profiles ranging from less than a nanometer to 10 micrometers.

Unique Self Detecting Cantilever

The cantilever incorporates a unique sensor that detects deflection. It is easy to install and operate. The optical axis does not need to be adjusted since it does not use a laser optical system, and can be taken anywhere for measurements.

Standard Vibration Isolation Mechanism

The provision of a vibration isolation mechanism that consists of a coil spring and gel damper allows measurements to be performed at virtually any location.

High-Speed Measurement

 High efficiency measurement of 12 seconds to 1800 seconds per frame is realized. The scanned profile can be monitored during measurement.



Principle of NPS2100A Sensor

The interaction (interatomic force or repulsion) that acts between the probes and the specimen surface is detected in order to measure the microscopic surface shape.





Analysis with TIMS Integrated Program



Roughness Analysis of Coating Film

Contour Anlysis of LCD Substrate

NPS2100A Applications

Semiconductors

Device pattern profile evaluation, film grain evaluation

Recording Media

Disk surface evaluation, chemical texture/bit profile evaluation, magnetic tape/magnetic head surface evaluation

Liquid Crystal · Other Displays

LCD panel surface evaluation, touch panel gap measurement, ITO film grain evaluation

Crystal Devices

Crystal oscillator/electrode surface roughness evaluation, SAW filter surface film thickness/step measurement

Ceramics · Glass

Surface/section profile evaluation, coating surface film thickness/step measurement, lens/optical filter profile evaluation

Electronic Devices

Surface profile evaluation, roughness/step measurement, plated surface evaluation, defect analysis

Molecular Materials

Polyamide film surface treatment evaluation, proccesed paper surface evaluation, paint film/coating film thickness/step measurement

Machine Tools

Grinding process evaluation, wear surface evaluation



Model		N P S 2 1 0 0 A
Measuring	X axis/Y axis	Max. 800 × 800 mm
range	Z axis	Max. ±10 μm
Resolution	Z axis	0.3 nm
Workpiece	Movement distance	10 mm in X, Y and Z directions
stand	Workpiece shape	Max. Ø60mm, Thickness: 8.5 mm
Scanning s	peed	12 seconds – 1800 seconds / frame
Measuring	modes	Contact mode, dumping mode
Evaluation functions		3D display, contour line display, Smeared contour display, contour line density display, section profile display, peak distribution display, airview (hidden line processing, mesh display, height color coding, view-poin direction specification), load curve display, amplitude distribution (ADF) display, peak height distribution displa
Standard accessories		Self detecting type cantilever (For contact mode:
		10 pieces/box, For Dumping mode: 10 pieces/box)
		pin set for cantilever, standard sample, optical
		microscope set, instruction manual

Specifications

High Precision Contour Measurement 1 µm or Less in Z Direction (for displacement of 5mm) CONTOURECORD 2600E



CONTOURECORD 2600E-12 * Printer is option.

Auto Element Judgment (AI Function)

Dimension Display Function

 The actual measured values for parameters and geometric deviation can be displayed on the diagram.

Profile Synthesis Function

The limitations on the analysis range due to the angle of the stylus are addressed with the synthesis function.

Peak and Valley Function

This function enables the maximum workpiece point to be detected by tracing with the stylus, simplifying alignment.

Calculation Point Repeat Function

 Overall workpiece analysis can be executed after completing only one pattern analysis for workpieces where certain shapes are repeated.

High Precision Contour Profile Evaluation

 The 2600E is ideal for the evaluation of non-spherical lenses, optical fiber connectors, ball screws and other parts where high profile accuracy is required.

Host of Contour Evaluation Functions

A wide range of evaluation are provided. Standard functions include a measured data (point data)/design value deviation collation function, design value generation function, best fit function and IGES/DXF conversion function to facilitate communication with CAD systems.



Surface Texture · Contour Measuring Instruments



Dimension line display function



Contour profile dimension analysis



Contour profile design value collation

10 📩	°	0 ~ 1 ~ 2 ~ 3 4	4.05.060		10		
Symbol	Actual	Nominal	Deviation	U-Tol	L-Tol	O-Tol	Auto element
404001 Jiam Roundness	Circle -0.861 10.044 0.017	Circle 0.800 10.000	0.061 0.044	0.050 0.050	-0.090 -0.050	0.011	Calculation type
K04002 Jine Angle Braightness K04003 K04004	Une 176.838 0.003 Intersection -2.658 Intersection	Une 177.000 0.000 A04001 A04002 Z A04001 A04002	-0.162 0.003 3.400	0.100 0.010	-1.000 0.000	-	P Auto element judge Points 0 Regist method Cursor Area
64006 CDM CDM	3.112 Caord Dif 6.770 0.319	Z A04003 A04004 5.700 0.380	3.081 0.070 0.019	0.050 0.050	-0.090 -0.090	0.020 ++	Entrys calc area Propost T 2 11022 New
							Carter Per

Calculation result/design value collation

Specifications	U		
Model		CONTOURECORD 2600E	
Measuring range	Z axis (vertical)	50 mm	
	X axis (horizontal)	100 mm (200 mm on -22 system)	
Accuracy	Z axis indication accuracy	\pm (0.8 + 4H / 100) μ m H: Measuring height (mm)	
	Measuring resolution	0.025 μm	
	X axis indication accuracy	\pm (1 + 2L / 100) μ m L: Measuring length (mm)	
	Measuring resolution	0.1 <i>µ</i> m	
Straightness accura	асу	1 μm / 100 mm	
Sensing method	Z axis	Laser beam diffraction scale	
	X axis	Moiré striped scale	
Recording	Vertical magnification	0.01~10,000,000 (Possible for any or automatic value)	
	Horizontal magnification	0.01~10,000,000 (Possible for any or automatic value)	
Speed	Column up/down (Z axis)	3 mm/s	
	Measuring (X axis)	0.03, 0.06, 0.15, 0.3, 0.6, 1.5, 3, 6 mm/s	
Min. measuring pitch		0.1 <i>µ</i> m	
Max. measuring points		100,000 (Max. 10 profiles)	
Radius of stylus		0.025 mm R	
Measuring force		30 mN or less	
Measuring feed dire	ction	Push/pull, both directions	
Measuring orientation	on	Up/down, both directions	
Calculation processing functions		Point, line, circle, partial circle, ellipse, max. point/min. point, distance, coordinate difference, polar coordinate difference, orthogonal/polar coordinate difference display, intersecting elements (point-line, line-line, circle-line, circle-circle, line-ellipse), symmetric elements (point-point, point-circle, point-ellipse, line-line, circle-circle, circle-ellipse, ellipse-ellipse), coordinate control (zero point setting, X axis setting, parallel movement, rotary movement), surface calculation, over-pin calculation, dimension line display function, calculation result/design value collation, mirror reversal, profile synthesis function, macro function, peak and valley function, auto operation log/playback function, profile design value collation, best fit, design value generation, IGES/DXF conversion	
Power source		Single phase AC 100 V ±10%, 50/60 Hz	
Power consumption	ı	380 VA	
Installation dimensi	ons	1400 (W) \times 800 (D) \times 750 (H) mm	
Weight		150 kg	

* Printer is not included in power consumption.



Cutting-Edge Linear Motor Dramatically Boosts Precision The New Standard in Contour Measuring

CONTOURECORD 1700DX



Higher Precision

A measuring accuracy that is adequate for measuring molds and other precision parts has been achieved. This dramatic increase in measuring precision enables measurement of workpieces that required a higher-end model in the past, substantially increasing the range of applications.

World's First Linear Motor in a Roughness Instrument (patent pending)

The world's highest level of measuring speed and lowest vibration enable consistent high-magnification measurements to be performed. The non-contact drive and simple structure (no feed screw or gear box) of the linear motor ensures stable vibration-free operation over an extended period.

High Efficiency Measurements

 The teaching/playback function automates the series of processes, from measurement to pasting of data to generate the inspection report.

A maximum measuring speed of 20 mm/s and maximum movement speed of 60 mm/s dramatically enhance measuring efficiency.

Space Saving

• A new design creates a fresh image, and the footprint has been reduced by approximately 25% (compared to previous model). This helps reduce expenses when installing the unit in a constant-temperature room.

Easy Evaluation of Contour of General-Purpose Parts (Contour)

Accurate data can be obtained quickly for the contour of parts that were evaluated with a projector or tool microscope in the past. The measuring results can be used as is on the inspection report.

Superior ACCRETECH Functions

Automatic Element Discrimination Function (AI Function) The element (point, line, circle) is automatically determined without being specified by the operator.

Dimension Line Display Function

This enables dimension lines to be drawn on the diagram along with actual measured values for parameters and geometric deviation.

Automatic Crowning Function

The maximum or minimum workpiece values are automatically detected.

Calculation Point Repeat Function

Overall analysis of workpieces with profiles that are repeated can be executed by analyzing only one pattern.

Workpiece Trace Function

The measuring range can be determined without setting the values by manually tracing the workpiece once.

This function is ideal for measurement of intricate shapes.

Import/Export Function

Image data can be pasted in the measured results, and measurement waveform data can be pasted in standard programs.





Specifications	}	
Model		CONTOURECORD 1700DX
Measuring range	Z axis (vertical)	50mm
	X axis (horizontal)	100mm
Accuracy	Z axis indication accuracy	\pm (2.5+ 2H /100) μ m/5mm range, 20mm range, \pm (3.5+ 4H /100) μ m/50mm range H: Measuring height (mm)
	Measuring resolution	0.1 μ m/5mm range, 0.4 μ m/20mm range, 1 μ m/50mm range
	X axis indication accuracy	±(1+2L/100) μm L: Measuring length (mm)
	Measuring resolution	0. 04 <i>µ</i> m
Straightness accura	acy	1 μm / 100 mm
Sensing method	Z axis	Differential transducer (trans)
	X axis	Moiré striped scale
Recording	Vertical magnification	0.01 – 10,000,000 (Possible for any or automatic value)
	Horizontal magnification	0.01 – 10,000,000 (Possible for any or automatic value)
Speed	Column up/down (Z axis)	10 mm/s
	Measuring (X axis)	0.03 - 20 mm/s
Min. measuring pitch		1 µm
Max. measuring points		100,000 (Max. 10 profiles)
Radius of stylus		0.025 mm R
Measuring force		30 mN or less
Measuring feed dire	ction	Push/pull, both directions
Measuring orientation	on	Up/down, both directions
Calculation processing functions		Point, line, circle, partial circle, ellipse, max. point/min. point, distance, coordinate difference, polar coordinate difference, orthogonal/polar coordinate difference display, intersecting elements (point-line, line-line, circle-line, circle-circle, line-ellipse), symmetric elements (point-point, point-circle, point-ellipse, line-line, circle-circle, circle-ellipse, ellipse-ellipse), coordinate control (zero point setting, X axis setting, parallel movement, rotary movement), surface calculation, over-pin calculation, dimension line display function, calculation result/design value collation, mirror reversal, profile synthesis function, macro function, automatic element discrimination, calculation point repeat function, workpiece trace function, peak and valley function, auto operation log/playback function, profile design value collation, best fit, design value generation, IGES/DXF conversion
Power source		Single phase AC 100 V ±10%, 50/60 Hz
Power consumption	ı	400VA
Installation dimensi	ons	1250 (W) × 850 (D) × 1500 (H) mm
Weight		125kg



Enhanced Operational Ease

CONTOURECORD 1600D



* Printer is option.

Auto Element Judgment (Al Function)

• The 1600D automatically determines the type of element (point · line · circle).

Dimension Display Function

• The actual measured values for parameters and geometric deviation can be displayed on the diagram.

Profile Synthesis Function

• The limitations on the analysis range due to the angle of the stylus are addressed with the synthesis function.

Peak and Valley Function

• This function enables the maximum workpiece point to be detected by tracing with the stylus, simplifying alignment.

Calculation Point Repeat Function

• Overall workpiece analysis can be executed after completing only one pattern analysis for workpieces where certain shapes are repeated.

Workpiece Trace Function

• The measuring range can be determined by tracing the workpiece once. This is effective for measurement of minute profiles.

Easy Evaluation of Part Contour

Exact data on parts that were previously evaluated with a projector or tool microscope can be obtained in a short period of time. The measured results can be used as is for inspection reports.

High Efficiency Measurement

• The teaching/playback function automates the entire process, from measurement to pasting of the data into an inspection report.





Dimension line display function



Overlap display



Printed data sheet

Specifications		
Model		CONTOURECORD 1600D
Measuring range Z axis (vertical)		50 mm
	X axis (horizontal)	100 mm (200 mm on –22 system)
Accuracy	Z axis indication accuracy	\pm 0.25% / full scale (\pm 4 μ m or less for 5mm range)
	Measuring resolution	0.1 μm / 2.5 ±2.5mm, 0.4 μm / ±10mm, 1 μm / ±25mm
	X axis indication accuracy	\pm (1 + 2L / 100) μ m L: Measuring length (mm)
	Measuring resolution	0.1 µm
Straightness accura	ю	1 μm / 100 mm
Sensing method	Z axis	Differential transducer (trans)
	X axis	Moiré striped scale
Recording	Vertical magnification	0.01 - 10,000,000 (Possible for any or automatic value)
	Horizontal magnification	0.01 – 10,000,000 (Possible for any or automatic value)
Speed	Column up/down (Z axis)	3 mm/s
	Measuring (X axis)	0.03, 0.06, 0.15, 0.3, 0.6, 1.5, 3, 6 mm/s
Min. measuring pitch		1 µm
Max. measuring points		100,000 (Max. 10 profiles)
Radius of stylus		0.025 mm R
Measuring force		30 mN or less
Measuring feed dire	ction	Push/pull, both directions
Measuring orientation	on	Up/down, both directions
Calculation processing functions		Point, line, circle, partial circle, ellipse, max. point/min. point, distance, coordinate difference, polar coordinate difference, orthogonal/polar coordinate difference display, intersecting elements (point-line, line-line, circle-line, circle-circle, line-ellipse), symmetric elements (point-point, point-circle, point-ellipse, line-line, line-line, circle-ellipse, ellipse-ellipse), coordinate control (zero point setting, X axis setting, parallel movement, rotary movement), surface calculation, over-pin calculation, dimension line display function, calculation result/design value collation, mirror reversal, profile synthesis function, macro function, auto operation log/playback function, profile design value collation, best fit, design value generation, IGES/DXF conversion
Power source		Single phase AC 100 V ±10%, 50/60 Hz
Power consumption	1	380 VA
Installation dimensi	ons	1850 (W) × 800 (D) × 750 (H) mm
Weight		150 kg

* Printer is not included in power consumption.

ZACCRETECH TOKYO SEIMITSU

Highly Reliable, Easy to Operate Unit for Internal Sections

CONTOURECORD 600D



Easy Measurement of Profile

The 600D facilitates easy and quick measurement of contour profiles with relatively large undulations, such as thread ridges, hole taper, mold profile and gauge contour profile.

High Precision

600

1

The unit has unique position detection mechanisms in the vertical (Z) and horizontal (X) directions, enabling very accurate and reliable enlarged drawing of profiles with a high-precision X-Y recorder.

Facilitates Difficult Measurements

 This unit can measure internal sections and other profiles that cannot be measured with a projector or tool microscope unless the workpiece is cut.

Outstanding Operational Ease

 The X axis and Y axis can be motor fed with a joystick or manually fed, enhancing the efficiency of measurements.

Select Optimum Measuring Magnification/Speed

 The optimum measuring magnification between 1 and 2,000 times can be selected according to individual requirements. (500 to 2000 magnification are optional.)

Arc Distortion Correction Function

This function automatically corrects for arc distortion caused by the lever type detector. The function even works when using a special long arm, reversing the arm or other special method, ensuring accurate recording.



Measure Long Holes/Large Workpieces
 Long holes can be measured by using a special arm that is longer than the standard arm.



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Various Safety Mechanisms

The 600D incorporates a variety of safety mechanisms, including an electric retract mechanism to prevent breakage of the stylus tip and an overload auto-stop function to protect the detector by monitoring for overscale or sticking of the stylus.

Sample Data Sheet

Plastic gear measurement





Plastic bolt profile measurement



Specifications

Model		CONTOURECORD 600D	
Measuring range	7 axis (vertical)		
Measuring range	X axis (vertical)	100 mm (200 mm on -22 system)	
Acourcov	7 axis indication accuracy		
Accuracy	Z axis indication accuracy		
0	A axis mulcation accuracy		
Straightness accura	icy	$1 \mu\text{m}/100\text{mm}$	
Sensing method	Z axis	Differential transducer (trans)	
	X axis	Moiré striped scale	
Recording	(Z axis)	1, 2, 5, 10, 20, 50, 100, 200, 500*, 1000*, 2000*	
	Horizontal magnification (X axis)	1, 2, 5, 10, 20, 50, 100, 200, 500*, 1000*, 2000*	
Speed	Column up/down (Z axis)	3 mm/s	
Measuring (X axis)		0.03, 0.06, 0.15, 0.3, 0.6, 1.5, 3, 6 mm/s	
Min. measuring pitch		1 <i>µ</i> m	
Stylus Tip radius Material		25 μm R	
		Carbide alloy	
Measuring force		30 mN or less	
Measuring feed direction		Change between push measurement and pull measurement	
Measuring orientation	on	Change between upward measurement and downward measurement	
Stylus follow angle	Up	Max. 77° (smooth surfaces)	
	Down	Max. 87° (smooth surfaces)	
Power source		Single phase AC 100 V ±10%, Specify 50 or 60 Hz	
Power consumption		300 VA	
Installation dimensi	ons	1200 (W) \times 450 (D) \times 717 (H) mm**	
Weight		120 kg**	
Standard accessorie	es	Stylus (DT45502), recording paper (A3 leaf), ceramic pen (red, HC503P-RD), set of tool consumables, instruction manual,	
		inspection certificate	

Low Measuring Force Adjustment Function (option)

This function enables measurements to be performed on easily deformed workpieces with a low measuring force of 2 mN. Low measuring force adjustment weight (0102406)

Min. measuring force: 2mN Measuring force range: 2 – 10 mN Adjustment: 1 mN / graduation



Pull-top measurement





Flashlight mirror measurement



*: Indicates high-magnification detector. **: Specifications for -12 system





PS200 Profile Scanner

Non-Contact Contour Profile Measurement

This revolutionary product enables the contour profile of multiple refraction materials to be measured.

Wide Measuring Range

Measurements can be performed between 0 mm and 35 mm by changing the objective lens. A wide work distance range of 9 - 70 mm enhances operation ease.

Wide Angle Measurement

The use of scattered light achieves a measuring angle of 85 degrees.

High-Speed Measurement

The maximum measuring speed of 50 mm/sec. is equal to 10 times the efficiency of conventional units.

Ideal for Soft Materials

The PS200 is ideal for soft workpieces that were difficult to measure in the past, such as rubber that is easily deformed (can be measured with black), leaf springs that experience elastic deformation with only a small amount of measuring force, seals and other materials that are soft and cannot be measured with the contact method.

Extensive Application Technology

The PS200 can be used as a digitizer and connected to a CAD, free curve program or other network to facilitate reverse engineering



Digitizing with PS200

Point group data generation by DIMENSION program (option)



Collation of point group data and CAD data by HOLOS program (option)





measured



Example of break pad wear evaluation





Example of silicon wafer slicing accuracy







Specifications

Model				PS 20	0		
Measuring range	Z axis (ve	rtical)	0 – 35 mm (selected by changing	0 – 35 mm (selected by changing objective lens)			
	Y axis (fro	nt/rear)	200 mm				
	X axis (ho	rizontal)	200 mm				
Objective lens	Resolution	n	0.15 – 4 μ m (selected by changing	g objective lens)			
	Work dista	ance	9 - 70 mm (selected by changing	objective lens)			
Straightness	Y axis (fro	nt/rear)	2 µm / 200 mm				
accuracy	X axis (ho	rizontal)	2 µm / 200 mm				
Sample data	Max. measu (X axis)	ring points	7,000 points				
	Lines (Y a	xis)	2,000 lines				
Measuring speed	X axis (ho	rizontal)	Max. 50 mm/s				
Feed pitch	Y axis (fro	nt/rear)	0.001 – 10 mm				
Analysis items	Processing	Basic	Point, line, circle, partial circle, elli	pse, max. point/min. point, dis	tance, coordinate difference, p	olar coordinate difference,	
	functions		orthogonal/polar coordinate differ	ence display, intersecting elem	ents (point-line, line-line, circle	e-line, circle-circle,	
			line-ellipse), symmetric elements	(point-point, point-circle, point-	ellipse, line-line, circle-circle, o	circle-ellipse, ellipse- ellipse),	
		Additional	Over-pin calculation, dimension lin	ne display function, calculation	result/design value collation,	mirror reversal,	
			profile synthesis function, area calculation, macro function, automatic element discrimination (AI),				
			calculation point repeat function,	workpiece trace function, peak	and valley function, auto oper	ation log/playback function	
		3D	3D display, contour line display, sr	meared contour display, contou	ur line intensity display, section	n profile display,	
		display	load curve display, amplitude distr	ribution (ADF) curve display, p	eak height distribution display	ecilication),	
Power source			Single phase 100 V $\pm 10\%, 50/60$	Hz			
Power consumption			350 VA				
Installation dimensi	ons		1300 (W) \times 800 (D) \times 800 (H) mm	1			
Weight	Weight 280 kg						
Lenses							
Model	Ту	vpe I	Туре 🏾	Туре 🏢	Type Ⅳ	Type ∨	
Measuring range	C).6 mm	1.8 mm	8 mm	18 mm	35 mm	
Resolution (1 σ)	0	.15 µm	0.4 <i>μ</i> m	1 <i>µ</i> m	2 µm	4 μm	
	0.00	m/0.2 mm	2 //m/0.0 mm	6.11m/4.mm	10. //m/0.mm	1E //m/17 E mm	

* Power consumption does not include printer.

Work distance

Spot diameter

4 μm/0.6 mm

12 mm

 $5 \times 11 \mu m$

ACCRETECH TOKYO SEIMITSU

12 μ m/8 mm

42 mm

 $15 imes 45 \ \mu m$

20 μ m/18 mm

65 mm

 $25 \times 65 \ \mu m$

30 µm/35 mm

90 mm

 $35 imes 75 \ \mu m$

6 μm/1.8 mm

15 mm

 $12 \times 22 \ \mu m$

Efficient Non-Contact Measurement of Steep Profiles

PS100 Profile Scanner



Features

High-Speed Measurement

• The PS100 provides a measuring speed that is equal to 10 times the efficiency of conventional units (compared to ACCRETECH unit).

Low Running Costs

 This unit enables line-side measurements to be made very economically. Running costs are especially low since no consumables are required for the non-contact stylus.

High Measuring Efficiency

The unit is easy to operate and provides high throughput. Operation can be automated by using the teaching function to register all procedures, from measurement to analysis and printout.

Wide Measuring Range

 By changing the lens, non-contact measurements of profiles up to a maximum of 35 mm can be performed.

Non-Contact Measurement of Steep Profiles

Steep profiles can be easily measured. Normally, a measuring angle between 20 and 30° is the limit for optical measurements, but the PS100 is capable of a steep angle in excess of 80°.

CCD Multirefraction material Beam splitter Beam splitter Beam splitter Beam splitter CCD Polarization plates Semiconductor laser Objective lens tem being measured

Measurement Principle





PET bottle mouth profile



Embossed paper profile



Wafer cutting plate profile



Ceramic chip flatness

Paper cup stock profile

Contraction of the second seco

Specifications

Model				PS 10	0	
Measuring range	Z axis (ver	rtical)	0 – 35 mm (selected by changing objective lens)			
	X axis (ho	rizontal)	200 mm			
Objective lens	Resolution	n	0.15 – 4 μ m (selected by changing	g objective lens)		
	Work dista	ance	9-70 mm (selected by changing	objective lens)		
Straightness accuracy	X axis (ho	rizontal)	2 µm / 200 mm			
Sample data	Max. measu (X axis)	ring points	7,000 points			
Measuring speed	X axis (ho	rizontal)	Max. 50 mm/s			
Analysis items	Processing	Basic	Point, line, circle, partial circle, elli	pse, max. point/min. point, dis	tance, coordinate difference, p	polar coordinate difference,
	functions		orthogonal/polar coordinate different	ence display, intersecting elem	ents (point-line, line-line, circle	e-line, circle-circle,
			line-ellipse), symmetric elements	(point-point, point-circle, point-	ellipse, line-line, circle-circle, d	circle-ellipse, ellipse- ellipse),
		Additional	Over-pin calculation, dimension lin	ne display function, calculation	result/design value collation,	mirror reversal,
			profile synthesis function, area ca	Iculation, macro function, auto	matic element discrimination (AI),
			calculation point repeat function, v	workpiece trace function, peak	and valley function, auto oper	ration log/playback function
Power source		Single phase 100 V ±10%, 50/60 Hz				
Power consumption	*		430 VA			
Installation dimensi	ons		1200 (W) \times 800 (D) \times 950 (H) mm	I		
Weight			170 kg			
Lenses						
Model	Ty	ype I	Туре 🏾	Туре 🏢	Type Ⅳ	Type ∖⁄
Measuring range	0).6 mm	1.8 mm	8 mm	18 mm	35 mm
Resolution (1 σ)	0.	.15 µm	0.4 <i>µ</i> m	1 <i>µ</i> m	2 µm	4 <i>µ</i> m
Accuracy (2 σ)	2 <i>µ</i> r	m/0.3 mm	3 µm/0.9 mm	6 µm/4 mm	10 µm/9 mm	15 μm/17.5 mm
	4 <i>μ</i> ι	m/0.6 mm	6 μm/1.8 mm	12 µm/8 mm	20 µm/18 mm	30 µm/35 mm
Work distance	1	12 mm	15 mm	42 mm	65 mm	90 mm
Spot diameter	5 >	×11 μm	12 × 22 μm	$15 imes 45 \ \mu m$	$25 imes 65 \ \mu$ m	$35 imes 75 \ \mu$ m

* Power consumption does not include printer.



SURFCOM · CONTOURECORD System Configuration >>>

SURFCOM · CONTOURECORD System Configuration





* The optional printer can be an A3/A4 printer, laser printer or color printer.



* Drive unit model differs for SURFCOM 480A

E-RM-S72B→E-RM-S71A

E-RM-S74A→E-RM-S73A

E-RM-S141A→E-RM-S78A

 * -4], -5] and -6] configurations not available for the CONTOURECORD series.



Surface Texture · Contour Measuring Instruments

SURFCOM·CONTOURECORD Options >>>

Nosepieces

Applicable Models

S130A S480A S1400D, S1400D-3DF S1800D, S1800D-3DF S2800E, S2800E-3DF

Measuring Application	Model	Outer Appearance	Applicable Stylus	Skid Shape	Remarks
General purpose	010 2701		010 2501 DT43801	32mmR sapphire	 Tip skid Standard pickup built in
Skidless	010 2702*	11.5 10.5 67.5 11.5 10.5 67.5 1.5 10.5 67.5 1.5 10.5 67.5	All styluses		 For protection For front travel adjustment
Horizontal tracing of ordinary planes	010 2703*	9.3 	010 2501 DT43801		 Both side override skid Skid radius for horizontal tracing: 4.5mm
Extra fine holes	010 2704	02 ± 0.8	010 2511 DT43811	8mmR tool steel	 Double sided straddling skid Position adjustment with stylus required
Fine holes	010 2705		010 2512 DT43812	8mmR tool steel	• Tip skid
Thin groove tooth surfaces	010 2706		010 2512 DT43812	8mmR tool steel	Double sided straddling skid
Curved surfaces	010 2707		010 2515 DT43815	32mmR sapphire	Sliding skid
Deep grooves	010 2708		010 2515 DT43815	32mmR sapphire	Double sided straddling skid
Narrow deep grooves	010 2709*		010 2515 DT43815	32mmR sapphire	• Tip skid
R grooves	010 2710*		010 2515 DT43815	0.8mmR ruby	 One side override skid Magnification: 5,000 or more Position adjustment with stylus required Recording only
Small round bars	010 2711		010 2501 DT43801	32mmR sapphire	 Double sided straddling skid Skid position adjustment required Three types of skis provided for φ2 - 4, φ4 - 8, φ8 - 16
Long holes	010 2722*	ø7.5 <u>+</u>	010 2522 DT43822	32mmR sapphire	• Tip skid
Deep grooves in holes	010 2723		010 2525 DT43825	32mmR sapphire	 Tip skid Position adjustment with stylus required
Extra deep grooves	010 2724		010 2526 DT43826	32mmR sapphire	 Double sided straddling skid Position adjustment with stylus required
Bottom surface of O-ring grooves	010 2726		010 2525 DT43825	0.8mmR ruby	 Double sided straddling skid Magnification: 5,000 or more Position adjustment with stylus required

* Indicates stylus/nose piece set (DT43800 and 010 2640).





SURFCOM·CONTOURECORD Options >>>

Replaceable Profile Styluses

Applicable Models

 S130A
 S1400D, S1400D-3DF

 S480A
 S1800D, S1800D-3DF

S2800E, S2800E-3DF

Measuring Application	Model	Outer Appearance	Specifications	Remarks
General purpose	DT43801	3 4 	2µmR, 60° conical diamond, 0.7mN	 All orientations Horizontal tracing possible Standard specifications
Fine wires, knife edges	DT43802	3 4 - 0 - 02 - 02 - 02 - 02 	2µmR, 60° ax-shaped diamond, 0.7mN	Downward measurements
Extra fine holes, gear flank	DT43811	0.9 7 (0.5) 0.9 0.9 0.9 0.9 0.9 0.9 0.9 0.9	2µmR, 60° conical diamond, 0.7mN	 All orientations Horizontal tracing possible
Fine holes/ thin grooves	DT43812*	0.7 0.7 0.7 0.7 0.7 0.7 0.7 0.7	2µmR, 60° conical diamond, 0.7mN	 All orientations Horizontal tracing possible
Hole bottom/ conical surfaces	DT43813	o1 15' 15' 15' 15' 15' 15' 15' 15	2µmR, 60° conical diamond, 0.7mN	All orientationsHorizontal tracing possible
Corners/ tooth surfaces	DT43814*	e12 e2.7 8 5.7	2µmR, 60° conical diamond, 0.7mN	 All orientations Horizontal tracing possible
Deep grooves, round grooves	DT43815*	3 15 (1.1)	2μmR, 60° conical diamond, 0.8mN	Downward measurements Large waveform distortion
Fine long holes	DT43821	1.7 + 0.8 40.7 73.5 (0.7) (0.7) 73.5 5.7	2µmR, 60° conical diamond, 3mN	 Downward measurements Sensitivity: 1/2 Magnification: ×10,000 or less
Low magnification, long holes	DT43822*	3 4 7 2	2μmR, 60° conical diamond, 3mN	 Downward measurements Sensitivity: 1/2 Magnification: ×20,000 or less
Low magnification, corners	DT43824	e2.7 8 73.5 5.7	2µmR, 60° conical diamond, 4mN	 Downward measurements Sensitivity: 1/2 Magnification: ×20,000 or less
Deep groove corners	DT43827	35 03 73.5 5.7	2µmR, 60° conical diamond, 4mN	 Downward measurements Sensitivity: 1/2 Magnification: ×10,000 or less
Deep hole grooves, O ring groove bottom surfaces	DT43825	3 15 15 15 17 15 17 15 17 15 17 15 17 15 17 15 17 15 17 15 17 15 17 15 17 15 17 15 17 15 15 15 15 15 15 15 15 15 15	2μmR, 60° conical diamond, 3.4mN	 Downward measurements Sensitivity: 1/2 Magnification: ×20,000 or less Large waveform distortion
Extra deep grooves	DT43826	32 + 03 32 73.5 5.7	2µmR, 60° conical diamond, 4mN	 Downward measurements Sensitivity: 1/2 Magnification: ×10,000 or less Large waveform distortion
High magnification, contour profiles	DT43828	7 4 4 - 1.2 57.5 73.5 5.7	2µmR, 60° conical diamond, 3mN	 Downward measurements Sensitivity: 1/2 Magnification: ×10,000 or less
Stylus set	DT43800	A CONTRACTOR	2µmR	Nosepiece: 010 2702, 010 2703, 010 2709, 010 2710, 010 2722 Stylus: DT43812, DT43814, DT43815, DT43822

* Indicates stylus/nose piece set (DT43800). Measuring force is value when E-DT-S03A/E-DT-SE19A is mounted.



Replaceable Profile Styluses

Applicable Models

S130A S480A S1400D, S1400D-3DF S1800D, S1800D-3DF S2800E, S2800E-3DF

Measuring Application	Model	Outer Appearance	Specifications	Remarks
General purpose	010 2501	7 -01.2 02.7 -0.8	5µmR, 90° conical diamond, 4mN	 All orientations Horizontal tracing possible
Fine wires, Knife edges	010 2502		5µmR, 90° knife edge-shaped diamond, 5mN	
Medium fine holes	010 2509	$\begin{array}{c} \bullet & \bullet \\ 2.6 & \bullet \\ \hline \bullet & \bullet \\ \hline \bullet & \bullet \\ \hline \bullet & \bullet \\ 0.7 & \bullet \\ 0.7 \end{array}$	5μmR, 90° conical diamond, 4mN	 All orientations Horizontal tracing possible
Extra fine holes/ gear flank	010 2511		5µmR, 90° conical diamond, 4mN	 All orientations Horizontal tracing possible
Fine holes/ thin grooves	010 2512*	$1.7 \frac{1}{7} \xrightarrow[]{0.7} 15 \xrightarrow[]{1.7} 15 \xrightarrow[]{$	5µmR, 90° conical diamond, 4mN	 All orientations Horizontal tracing possible
Hole bottom/ conical surfaces	010 2513		5μmR, 90° conical diamond, 4mN	 All orientations Horizontal tracing possible
Corners/ tooth surfaces	010 2514*		5μmR, 60° conical diamond, 4mN	 All orientations Horizontal tracing possible
Deep holes, round grooves	010 2515*	15 → 01.2	5µmR, 90° conical diamond, 5mN	
Gear tooth profiles, thread flank	010 2518	90' 40' 0.2~0.3 0.9 0.9 0.9 0.9	5μmR, 90° conical diamond, 4mN	 Magnification: ×20,000 or less
Fine long holes	010 2521	$\begin{array}{c} \bullet 1.2 \\ 1.7 \\ 1 \\ 1 \\ 1 \\ 1 \\ 1 \\ 1 \\ 0.7 \end{array}$	5µmR, 90° conical diamond, 5mN	 Sensitivity: 1/2 Magnification: ×10,000 or less
Low magnification, long holes	010 2522*		5µmR, 90° conical diamond, 5mN	 Sensitivity: 1/2 Magnification: ×20,000 or less
Low magnification, corners	010 2524	30° 01.2 62	5µmR, 60° conical diamond, 5mN	 Sensitivity: 1/2 Magnification: ×20,000 or less
Deep groove corners	010 2527		5µmR, 60° conical diamond, 8mN	 Sensitivity: 1/2 Magnification: ×10,000 or less Large waveform distortion
Stylus set	010 2640	All and a second se	5µmR	Nosepiece: 010 2702, 010 2703, 010 2703, 010 2709, 010 2710, 010 2722 Stylus: 010 2512, 010 2514, 010 2515, 010 2522

* Indicates stylus/nose piece set (010 2640).

Measuring force is value when E-DT-S01A/E-DT-SE18A is mounted.



SURFCOM·CONTOURECORD Options >>>

Replaceable Profile Styluses

Applicable Models

 S130A
 S1400D, S1400D-3DF

 S480A
 S1800D, S1800D-3DF

S2800E, S2800E-3DF

Measuring Application	Model	Outer Appearance	Specifications	Remarks
Soft material $\underbrace{(j_1,j_1)_{j_1,j_2}}_{j_1,j_1,j_2}$	010 2508		10µmR, 90° conical diamond, 0.7mN	 All orientations Horizontal tracing possible Specifications are for when E-DT-S02A is mounted
Deep hole grooves- bottom surface of O ring grooves	010 2525	15 + 01.2 0.8	10µmR, 90° conical diamond, 8mN	 Downward measurements Sensitivity: 1/2 Magnification: x25,000 or less Large waveform distortion
Extra deep grooves	010 2526		10µmR, 90° conical diamond, 8mN	 Downward measurements Sensitivity: 1/2 Magnification: ×10,000 or less Large waveform distortion
Bottom surface of holes	010 2541	<i>e</i> 2.7 5 <u>1</u> − − − − − − − − − − − − − − − − − − −	10µmR, 90° conical diamond, 8mN	 Magnification: ×20,000 or less Large waveform distortion Dedicated connecting rod used
High magnification measurement	010 2506	2.7 4 (1.1) -00.8 33.5 5.7	1μmR, 60° conical diamond, 0.7mN	 All orientations Horizontal tracing possible Specifications are for when E-DT-S04A is mounted
High magnification contour profiles	010 2528	4 − + + + + + + + + + + + + +	1μmR, 60° conical diamond, 8mN	 Downward measurements Sensitivity: 1/2 Magnification: ×10,000 or less

* Measuring force is value when E-DT-S01A/E-DT-SE18A is mounted.

Replaceable Profile Styluses

Applicable Models

S130A S480A S1400D, S1400D-3DF S1800D, S1800D-3DF S2800E, S2800E-3DF

Measuring Application	Model	Outer Appearance	Specifications	Remarks
Steps	010 2504		250µmR, 60° conical sapphire, 5mN	All orientations
Waviness	010 2505**	7.5 → 01.6 → 22 →	800µmR, ruby, 4mN	All orientations
Extra fine hole profiles	010 2510		250µmR, tool steel, 4mN	 All orientations Magnification: ×5,000 or less
Fine long hole waviness	010 2520		800µmR, ruby, 5mN	 Downward measurements Sensitivity: 1/2 Magnification: ×10,000 or less
Large steps	010 2523		250 μ mR, sapphire, 5mN	Downward measurements Sensitivity: 1/2 Magnification: ×25,000 or less

** Items not denoted with two asterisks are manufactured after receipt of order. Measuring force is value when E-DT-S01A/E-DT-SE18A is mounted.



Pickups

Applicable Models

S480A

S1400D, S1400D-3DF S1800D, S1800D-3DF S2800E, S2800E-3DF

Measuring Application	Model	Outer Appearance	Specifications	Remarks
General purpose	E-DT-S01A	ø9.3 <u>↓</u> 09.3 <u>↓</u> 1 ↓ ↓ 5.5 021.7	5μmR, 90° conical diamond, 4mN	 All orientations Horizontal tracing possible Provided with 0102501 dedicated stylus
Soft materials $ \int_{\frac{1}{\sqrt{1}}}^{1} \int_{\frac{1}{\sqrt{1}}}$	E-DT-S02A	09.3 09.3 09.3 09.3 09.3 00.1 00	10µmR, 90° conical diamond, 0.7mN	 All orientations Horizontal tracing possible Provided with 0102508 dedicated stylus
Low measuring force	E-DT-S03A	ø9.3 <u>↓</u> 27.5 67.5 09.3 <u>↓</u> 021.7	2μmR, 60° conical diamond, 0.7mN	 All orientations Horizontal tracing possible Standard specifications Provided with DT43081 dedicated stylus
High magnification	E-DT-S04A	ø9.3 <u>↓</u> <u>27.5 67.5</u> <u>0</u> 21.7	1μmR, 60° conical diamond, 0.7mN	 All orientations Horizontal tracing possible Provided with 0102506 dedicated stylus
Non-continuous measurement	E-DT-S05A	09.3 09.3 09.3 021.7 0	5μmR, 90° conical diamond, 4mN	 All orientations Horizontal tracing possible Front travel: 110 – 120μm Other specifications are same as for E-DT-S01A
Grooves in holes	E-DT-S06A		5µmR, 90° conical diamond, 4mN	 Front travel: 200µm Only for skidless measurement Max. magnification: ×10,000 Dedicated connecting rod required (010 2746) Provided with 0102542 dedicated stylus
Ultra deep grooves	E-DT-S07A	$ \begin{array}{c} & & & \\ & & & \\ & & & \\ & & & \\ & & & \\ & & & \\ & & & \\ & & & \\ \end{array} \right) \begin{array}{c} & & & \\ & & & \\ & & & \\ & & & \\ \end{array} \right) \begin{array}{c} & & & \\ & & & \\ & & & \\ \end{array} \right) \begin{array}{c} & & & \\ & & & \\ & & & \\ \end{array} \right) \begin{array}{c} & & & \\ & & & \\ & & & \\ & & & \\ \end{array} \right) \begin{array}{c} & & & \\ & & & \\ & & & \\ \end{array} \right) \begin{array}{c} & & & \\ & & & \\ & & & \\ & & & \\ & & & \\ & & & \\ \end{array} \right) \begin{array}{c} & & & \\ & & & \\ & & & \\ & & & \\ & & & \\ & & & \\ & & & \\ & & & \\ \end{array} \right) \begin{array}{c} & & & \\ & & & & \\ & & $	5μmR, 90° conical diamond, 4mN	 Front travel: 200µm Stylus cannot be replaced Max. magnification: ×10,000 Sensitivity: 1/2
Ultra long holes	E-DT-S08A	ø9.3 <u>i</u> t → t → 5.5 07.5 → 1 t → t → t → t → t → t → t → t → t → t →	5μmR, 90° conical diamond, 4mN	 Front travel: 200µm Stylus cannot be replaced Max. magnification: ×10,000 Sensitivity: 1/5
High magnification	E-DT-SH01A			 Max. magnification: ×500,000 Measuring force: 0.2mN Provided with 016 2854 stylus
	016 2854		1 μ mR, 90° conical diamond	
	010 2567	~1	1µmR, 60° conical diamond	
Stylus for	010 2210		10 μ mR, 60° conical diamond	
E-DT-SH01A	010 2211	<u>ø1.2</u>	5µmR, 60° conical diamond	
	010 2212		0.5µmR, 60° conical diamond	
	010 2213		90° 2.5µm width knife edge, diamond	
Thin pickup	DT42001		5μmR, 90° conical diamond, 10mN	 Magnification: ×5,000 or less Horizontal tracing possible Provided with 0102501 dedicated stylus
Pickup holder for thin pickup	E-DH-S60A	(6 181) (6 181)		Used for horizontal tracing of crankshaft pins, journals or other such parts
Non-contact measurement	E-DT-SL12B	14.5 11.5 117.5	Measuring range: $300 \mu m$ Spot diameter: $2\mu m$ Work distance: 4.5 mm	 Color confocal point type Light source: Halogen light bulb Life: 1000 H



SURFCOM·CONTOURECORD Options >>>

Replaceable Styluses for S3000A

Applicable Models S3000A, S3000A-3DF

Measuring Application	Model	Outer Appearance	Specifications	Remarks
General purpose	DM48505		2μmR, 60° conical diamond, 0.7mN	Stroke: 12mm Standard accessory For roughness & contour measurement
General purpose highly rigid stylus	DM48507		2µmR, 60° conical diamond, 0.7mN	Stroke: 12mm For roughness & contour measurement
Highly rigid stylus for contours	DM48508		500µmR, ruby ball, 0.7mN	Stroke: 24mm Standard accessory For contour measurement
Highly rigid stylus for contours	DM48509		500µmR, ruby ball, 3.2mN	Stroke: 30mm For contour measurement
Up/down measuring stylus	DM48510		2µmR, 60° conical diamond, 0.7mN	Stroke: 12mm For roughness & contour measurement
Right angle stylus	DM48511		2µmR, 60° conical diamond, 0.7mN	 Stroke: 12mm Offset: 13.5mm For roughness & contour measurement
Small hole stylus	DM48513		2µmR, 60° conical diamond, 0.7mN	Stroke: 12mm Stylus height: 2mm For roughness & fine contour measurement
Extra small hole stylus	DM48514		2µmR, 60° conical diamond, 0.7mN	Stroke: 12mm Stylus height: 1mm For roughness & fine contour measurement
Deep hole stylus	DM48515		2µmR, 60° conical diamond, 0.7mN	 Stroke: 12mm Stylus height: 25mm For roughness & contour measurement
General purpose stylus	DM48588		5µmR, 30° conical diamond, 0.7mN	Stroke: 12mm For roughness & contour measurement

S3000A Accessories

Measuring Application	Model	Outer Appearance	Specifications	Remarks
Dust cover	E-CV-S29A			For DX measuring stand
Dust cover	E-CV-S30A			• For STD (E-VS-R16A)



Contour Styluses

Applicable Models

E60A

C600D C1600D S1800D, S1800D-3DF

Measuring				ecificatio	ons	_ .
Application	Model	Outer Appearance	d	L1	L2	Remarks
General purpose	DT45501	ad D	3	60	52	
	DT45502	e ød → [+	3	34	26	
	DT45503	<u>24° conical, R0.025</u> \downarrow \downarrow \downarrow	2	21	13	
General purpose	DT45504	ød "D t	3	60	52	
	DT45505*		3	34	26	Standard accessory (C1600D_S1800D)
. () 3	DT45506	24° conical, R0.025	2	21	13	(C1700, S1900)
Edge line	DT45507		3	60	52	
Ē	DT45508*	Ød→l+	3	34	26	
	DT45509		2	21	13	
Small holes	DT45081			12	9	
	DT45082			7	5	
	DT45083	<u>R0.025</u>		3.5	1.5	
Small hole threads	DT45084*	5,		12	9	
	DT45085	24° conical, R0.025 65		7	5	
	DT45086*			3.5	1.5	
Ordinary offset	DT45087	25 65		12	9	• Offset: 25mm
	DT45088	L11 L2 <u>12° conical, R0.025</u> 17		7	5	
	DT45089			3.5	1.5	
Helix surface offset	DT45090	25 65		12	9	
	DT45091			7	5	Offset: 25mm
	DT45092	L2 <u>24° conical, R0.025</u> 17		3.5	1.5	
High precision	DT45522	ød →∏ ⊷†	3	60	52	
	DT45523		3	34	26	• ϕ 0.7 ruby ball
	DT45524		2	21	13	
High precision	DT45525		3	60	52	
	DT45526		3	34	26	・ <i>ゆ</i> 1 ruby ball
	DT45527	Ų ↓ L ⊂ ↓	2	21	13	

* Indicates stylus/arm set (010 2999).

ZACCRETECH TOKYO SEIMITSU

Stylus material: Cemented carbide

SURFCOM·CONTOURECORD Options >>>

Contour Arms

Applicable Models

E60A

C600D C1600D S1800D, S1800D-3DF

Measuring Application	Model	Outer Appearance	Applicable Stylus	Remarks
General purpose	010 2800	$\begin{array}{c} \downarrow \\ 26 \\ \hline \\ 178.5 \\ \hline \end{array} \begin{array}{c} \downarrow \\ 178.5 \\ \hline \end{array} \begin{array}{c} \downarrow \\ 178.5 \\ \hline \end{array}$	DT45502 DT45505 DT45508	
Inner surface	010 2801	13 10 178.5 10	DT45503 DT45506 DT45509	
Small holes	010 2802*		DT45081 DT45092	
Deep grooves	010 2804	10	DT45501 DT45504 DT45507	 Max. magnification: ×50 010 2744 pickup holder coupling required Provided with auxiliary weight
	010 2805		DT45502 DT45505 DT45508	 Max. magnification: ×100 Offset: 50mm Provided with auxiliary weight
Offset measurement	010 2806		DT45502 DT45505 DT45508	 Max. magnification: ×50 Offset: 100mm Provided with supplementary weight
	010 2807	50- 178.5 13 08	DT45503 DT45506 DT45509	 Max. magnification: ×100 Offset: 50mm
Long items	010 2808	10	DT45501 DT45504 DT45507	 Max. magnification: ×10 Lever movement range: 100mm Sensitivity: 1/2 Arc correction: 1/2 Provided with supplementary weight 010 2744 pickup holder coupling required
Long holes	010 2810	13 + 10 + 10	DT45503 DT45506 DT45509	 Max. magnification: ×25 Lever movement range: 100mm Sensitivity: 1/2 Arc correction: 1/2 Provided with supplementary weight
Arm/stylus set	010 2999			Styluses: DT45505, DT45508, DT45084, DT45086 Arms: 010 2802, 010 2805

* Indicates stylus/arm set (010 2999).



Contour Styluses

Applicable Models

odels C2600E

S2800E, S2800E-3DF

Stylus material: Cemented carbide

Measuring Application	Model	Outer Appearance	d	L1	L2	Remarks
General purpose	DT45501	ød →∏t	3	60	52	
	DT45502		3	34	26	
	DT45503	<u>R0.025</u>	2	21	13	
General purpose	DT45504	ød → ∏ →	3	60	52	
	DT45505*		3	34	26	Standard accessory
	DT45506	24° conical, R0.025	2	21	13	
Edge line	DT45507		3	60	52	
6	DT45508*		3	34	26	
\sim	DT45509		2	21	13	
Small holes	DT45510	-→ <u>5</u>		12	9	Macauring force: 10mN or loss
	DT45511			8	5	Deflection:
	DT45512			4.5	1.5	Approx. 1.5 μ m for Tomix
Small hole twist	DT45513*	-+ <mark> 5</mark> ←		12	9	
	DT45514			8	5	Measuring force. Tomix of less Deflection:
	DT45515*	24° conical, R0.025		4.5	1.5	Approx. 1.5 μ m for Turnin
Ordinary offset	DT45516	25, ~ ~ ~ ~ ~ ~ ~ ~ ~ ~ ~ ~ ~ ~ ~ ~ ~ ~ ~		12	9	Macouring force: 10mN or loss
	DT45517			8	5	Deflection: Approx. 3 //m for 10mN
	DT45518	L2 12° conical, R0.025		4.5	1.5	
Helix surface offset	DT45519	25 65		12	9	• Moosuring force: 10mN or loss
	DT45520			8	5	Deflection: Approx. 3 //m for 10mN
	DT45521	L2 24° conical, R0.025 17		4.5	1.5	
High precision						
	DT45580	03→ 0.5 ruby ball	3	21	13	· ¢0.5 ruby ball
High precision						
	DT45583	$\begin{array}{c ccccccccccccccccccccccccccccccccccc$				 φ0.5 ruby ball Integral with arm
High precision	DT45522		3	60	52	
	DT45523]	3	34	26	• ϕ 0.7 ruby ball
	DT45524	Ă↑↑	2	21	13	
High precision	DT45525	od I	3	60	52	
	DT45526		3	34	26	• ϕ 1 ruby ball
	DT45527	X ↑ ↑	2	21	13	

ZACCRETECH TOKYO SEIMITSU

SURFCOM·CONTOURECORD Options >>>

Contour Arms

Applicable Models

S2800E, S2800E-3DF

C2600E

Measuring Application	Model	Outer Appearance	Applicable Stylus	Remarks
General purpose	DT45528	$\begin{array}{c} & & & \\ & & & \\ & & & \\ & & & \\ & & & \\ & & & \\ & & & \\ \end{array}$	DT45502 DT45505 DT45508	Standard configuration (with supplementary weight) • Deflection: Approx. 1.2μm for 10mN Approx. 3.7μm for 30mN
Inner surface	DT45529	13 <u>1 108</u> → 178.5 → 10	DT45503 DT45506 DT45509	(Provided with supplementary weight) • Deflection: Approx. 1.2μm for 10mN Approx. 3.7μm for 30mN
Small holes	DT45530*	$17 \xrightarrow{\uparrow} 08 115 10$	DT45510 DT45521	Stylus combination arm for measuring small holes (with supplementary weight)
Deep grooves	DT45531		DT45501 DT45504 DT45507	 Measuring force: 10mN or less (with supplementary weight) Deflection: Approx. 1.2µm for 10mN Approx. 3.7µm for 30mN
Offset measurement	DT45532*		DT45502 DT45505 DT45508	 Measuring force: 10mN or less (with supplementary weight) Deflection: Approx. 2.6µm for 10mN Approx. 7.8µm for 30mN
	DT45533	50-178.5 13-00-08-00-00-00-00-00-00-00-00-00-00-00-	DT45503 DT45506 DT45509	 Measuring force: 10mN or less (with supplementary weight) Deflection: Approx. 2.6µm for 10mN Approx. 7.8µm for 30mN
Arm stylus set	DT45500			Styluses: DT45505, DT45508, DT45513, DT45515 Arms: DT45530, DT45532

* Indicates stylus/arm set (DT45500).



Adjustment Devices

Applicable Models

S480A

C600D

S1400D, S1400D-3DF S1800D, S1800D-3DF C1600D S3000A S2800E, S2800E-3DF C2600E

News	Model	Outer	Orthogonal Axis Adjustment (mm)		Swivel Adjustment		Tilting Adjustment		Table	Allowable	Demeriles	
Name	Model	Appearance	X	Y	Z	Fine	Rough	Fine	Rough	Size (mm)	Load (kg)	Remarks
Adjustment stand	E-AT-S01C ଷ		50	50		8°	360°			<i>ф</i> 150	15 (6)	Min. reading increment: 10µm
Leveling adjustment stand	E-AT-S02A							±1.5°		80×110	15 (3)	
Adjustment stand	E-AT-S03A			±2.5		±2°				80 × 58	3 (0.9)	For E-RM-S75A
Adjustment stand	E-AT-S04A			±8		±3°				80 × 125	15 (8)	
Adjustment stand	E-AT-S05A			±3		±1°				120 × 58	3 (1.4)	For E-RM-S76A
Adjustment stand	E-AT-S36A			±3		±1°				200 × 120	5 (4.5)	For E-RM-S77A
X direction movement adjustment stand	E-AT-S08A		400							150 × 150	20 (25)	
3D fine adjustment stand	E-AT-S10A		55	55	28					75×40	1 (3.4)	Straightness: 0.03mm
1-axis precision fine adjustment stand	E-AT-S11B			50						125 × 150	20 (4.9)	Straightness: 3µm Min. reading value: 10µm
Swivel fine rotation stand	E-AT-S12A					±5°	360°			<i>ф</i> 90	3 (0.58)	Min. reading value: 5'
1-axis ultra precision fine adjustment stand	E-AT-S13B			10 Coarse movement 10µm Fine movement 0.5µm						60 × 60	10 (0.7)	Straightness: 3µm Min. reading value: 0.5µm
Tilting stand	E-AT-S64B							±20°		60 × 120	10 (1)	Min. reading value: 5'
Universal stand	E-WJ-S03A						360°		±90°	<i>ф</i> 110	3 (2.5)	X/Y direction adjustment
Column rotary spacer	E-CS-S31A*1				H : 100		360°				(6)	Inserted between table and column
Column spacer	E-CS-S32A*1				H : 200							Inserted between table and column
Drive unit spacer	E-CS-S33A*1			L : 70								Inserted between column and drive unit
Drive unit tilting device	E-CA-S24A*2								±15°			For contour measurements
Drive unit tilting device	E-CA-S32A*2								±5°		(5)	For roughness measurements

*1 Indicates item cannot be used with S3000A series.

*² Indicates item cannnot be used with S1500, S1900, C1700 and S3000A series.

SURFCOM·CONTOURECORD Options >>>

Holders

Applicable	Models	S480A	S1400D S1800D C1600D	, S1400D-3D , S1800D-3D	OF S	53000A 52800E, S 52600E	2800E-3D	F	
Name	Model	Outer Appearance	V Holder (mm)	Chucking (mm)	Vice (mm)	Clamp (mm)	Flat Surface (mm)	Allowable Load (kg) (net wt.)	Remarks
Double-side open vice	E-WJ-S01B				ID: 59 OD: 38 – 105			5 (0.8)	
V stand set	E-WJ-S02A		φ1 – 150					(1.5)	Provided with workpiece clamper
V stand holder set	E-WJ-S04A	A.C.	ф12 – 150					(3)	Two pieces used just for T groove clamp
Compact stand	E-WJ-S05A		<i>ф</i> 4 – 10					(0.4)	
Load plate	E-WJ-S06A						150×150 Angle plate	(1)	
Static electricity holding plate	E-WJ-S11A						80×130 Angle plate	(1.3)	Holding strength: 0.2kg (Ideal for paper, aluminum, film)
Scroll chuck	E-WJ-R01C			OD: <i>φ</i> 2 – 75 ID: <i>φ</i> 56 – 91				(1)	
Clamp set	JC-3	and the second s				Height: 40 – 60			
Ceramic load plate	E-WJ-S252A						300 × 300 Angle plate	(5.3)	(Manufactured after receipt of order)
Ceramic load plate	E-WJ-S234A						500 × 500 Angle plate	(15)	(Manufactured after receipt of order)

Sample Adjustment Stand/Holder Configurations



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Peripheral Devices

Applicable Models

S480A

S1400D, S1400D-3DF S1800D, S1800D-3DF C1600D S2800E, S2800E-3DF

C2600E

Name	Model	Outer Appearance	Specifications	Remarks
	E-RM-S72B		$\begin{array}{llllllllllllllllllllllllllllllllllll$	 Weight: Approx. 9 kg S480A: E-RM-S71B (Specifications same as shown to left)
Pickup movement drive unit	E-RM-S74A		Drive distance: 200mm Drive speed: 0.03 – 6.0mm/s (8 speeds) Straightness accuracy: (0.05+1.5L/1000)µm	 Weight: Approx. 15 kg S480A: E-RM-S73A (Specifications same as shown to left)
	E-RM-S141A		Drive distance: 100mm Drive speed: 0.003 - 6.0mm/s (11 speeds) Straightness accuracy: (0.05+1.5L/1000)μm	 Weight: Approx. 9 kg S480A: E-RM-S78A (Specifications same as shown to left)
	E-RM-S75A		Drive distance: 50mm Drive speed: 0.03 – 6.0mm/s (8 speeds) Straightness accuracy: (0.05+1.5L/1000)µm	 Weight: Approx. 15 kg Load weight: 5 kg Leveling range: ±1.5°
Workpiece movement drive unit	E-RM-S76A		Drive distance: 150mm Drive speed: 0.03 – 6.0mm/s (8 speeds) Straightness accuracy: (0.05+1.5L/1000)µm	 Weight: Approx. 20 kg Load weight: 5 kg Leveling range: ±1°
	E-RM-S77A		Drive distance: 300mm Drive speed: 0.03 – 6.0mm/s (8 speeds) Straightness accuracy: (0.05+1.5L/1000)μm	 Weight: Approx. 32 kg Load weight: 10 kg Leveling range: ±0.8°
Outer periphery roughness drive unit	E-RM-S85A		Measuring OD:	• Weight: Approx. 7 kg • Load weight: 5 kg
Round surface roughness drive unit	E-RM-S84A		Measuring radius: 0.25 – 40mm Drive speed: ±0.25µm (Arvitrary 180°) Peripheral speed: 0.3 mm/s (stepless)	
Column cross feed device	E-ST-S131A	Z axis direction stroke: 650 <u>126.21</u> <u>180.</u> <u>1293</u> <u>11000</u> (113) <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u> <u>1110</u>	Action	 For measurement of large and heavy parts Weight: Approx. 370 kg (Manufactured upon receipt of order)
Auto tilting table	E-AT-S72A			 Leveling range: ±2° Load weight: 5 kg
Pickup holder stand	E-CA-S25A			 When workpiece movement drive unit is used Weight: Approx. 1.5 kg

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SURFCOM·CONTOURECORD Options >>>

Name	Model	Outer Appearance	Specifications	Remarks
Connecting rod for ultra long hole measurement	010 2736		Magnification: Up to 10,000 Min. inner dia.: Up to ϕ 25mm Max. depth: 650mm	 Used with large measuring stand For measurement of ultra long holes (skid measurement) Weight: Approx. 1.2 kg
Pickup holder coupling	010 2744		Coupling length: 30mm	 Used with 010 2804 contour profile arm Weight: Approx. 0.25 kg
Pickup holder coupling	010 2745		Measuring length: Up to 131mm beneath drive unit	• Weight: Approx. 0.47 kg
Pickup right angle coupling/ connecting rod	010 2746		Measuring length: 142mm beneath detector holder	 Pickup vertical measurement using hole bottom stylus Weight: Approx. 0.2 kg
Desktop vibration isolation stand	E-VS-S13A			Dimensions: 510 ^w × 430 ^o × 640 ^µ mm • Load: 22 kg • For E-VS-S28A, E-VS-S38A
Desktop vibration	E-VS-S57A/ (E-VS-S38A)		Vibration isolation: Pneumatic diaphragm spring Natural frequency: 1.5 – 3 Hz Load weight: 120 kg	Dimensions: 600 ^w × 500 ^b × 55 ^H mm • Air source: 350 – 700 kPa • Weight: 26 kg
	E-VS-S58A/ (E-VS-S28A)		Vibration isolation: Pneumatic diaphragm spring Natural frequency: 1.5 – 3 Hz Load weight: 120 kg	Dimensions: 600 ^w × 500 ^p × 55 ^H mm • Air source: Pump • Weight: 26 kg
Desktop vibration isolation stand	E-VS-S45A		Vibration isolation: Pneumatic diaphragm spring Natural frequency: 4 Hz Load weight: 300 kg	Dimensions: 1000 ^w × 750 ^p × 143 ^µ mm • Air source: Pump • Weight: 80 kg
Vibration	E-VS-R16A		Vibration isolation: Pneumatic diaphragm spring Natural frequency: V; 2Hz, H; 2.2Hz Load weight: 250 kg	 Dimensions: 980^w × 780^p × 700^Hmm Air source: 350 - 700 kPa Weight: 170 kg
isolation stand	E-VS-S21A	$\begin{array}{c c} \hline \\ \hline $	Vibration isolation: Pneumatic diaphragm spring Natural frequency: V; 1.6Hz, H; 2Hz Load weight: 550 kg	 Dimensions: 1100^W × 850^D × 700^Hmm Air source: 350 - 700 kPa Weight: 340 kg



Name	Model	Outer Appearance	Specifications	Remarks
System rack	E-DK-S24A			 Dimensions: 800^w × 800^p × 1070 – 1370^Hmm Load: 42 kg
System rack	E-DK-S25A			• Dimensions: $1200^{\text{w}} \times 800^{\text{o}} \times 1070 - 1370^{\text{H}}\text{mm}$
Side desk	E-DK-S10A			• Dimensions: $40^{\text{w}} \times 1070^{\text{D}} \times 700^{\text{H}}\text{mm}$
High magnification dust cover	E-CV-S02A	Transparent vinyl sheet		 Used with desktop vibration isolation stand/ ordinary stand for roughness measurement Dimensions: 750^w × 614^b × 810^Hmm Weight: 8 kg
High magnification dust cover	E-CV-S03A			 Used with desktop vibration isolation stand/ ordinary stand for contour profile measurement Dimensions: 1000^w × 629^o × 810^Hmm Weight: 13 kg
Dust cover	E-CV-S25A	+ 1070 → 1050 / - 750 → 1050 /		 Used with E-VS-S21A vibration isolation stand for large measuring stand Dimensions: 1070^w × 750^p × 1050^Hmm Weight: 20 kg Manufactured upon receipt of order
Measurement position verification unit	E-MA-S81A	Microscope >25 times croscope knob	Magnification: ×20 Focal distance: 60mm	Stand type
Measurement position verification unit	DM59014	Light guide (option) CCD camera (option) Microscope	Magnification: ×20 Focal distance: 60mm	 Can be used with workpiece movement drive unit
Light	E-MA-S83A	Flexible arm Light guide Flexible arm Fixing knob Suction Light guide Suction Light guide Suction Light guide Suction Light guide Light guide Suction Light guide Light guide Suction Light guide Light guide Light guide Suction Light guide Light gu		 Suction fixing method Surface unit is mounted on must be flat and free from holes, grooves, etc.
Light	E-MA-S84A	Fine movement knob Flexible arm Flexible arm Fixing knob		Stand type
Black & white camera monitoring system	DM59102	Light guide (option)	Image sensor: Interline type CCD Effective pixels: 768 × 494	Configuration (1) Black & white camera (2) Black & white monitor (3) Power adapter (4) Microscope adapter (5) Connection cable (6) Instruction manual
Color camera monitoring system	DM59103	(sold separately)	Image sensor: Interline type CCD Effective pixels: 768 × 494	Configuration(1) Color camera(2) Color monitor(3) Power adapter(4) Microscope adapter(5) Connection cable(6) Instruction manual





SURFCOM·CONTOURECORD Options >>>

Model	Outer Appearance	Outer Appearance	Remarks
DT58526			 For pickup movement drive unit (manufactured after receipt of order)
E-MC-S24B		Calibration surface: Approx. 3.1 μmRa Actual measured value denoted	 For magnification calibration and checking stylus
E-MC-50B		Narrow range accuracy: 0 – 10 μ m ±0.1 μ m Wide range accuracy: 0 – 400 μ m ±0.1 μ m	For magnification calibration
E-MC-S34A	71+ (Block gauge) Master ball 012.7mm (1/2) 46 46 46 46 46 46 46 46 46 46		 For measurements with stylus pointing downward For C1600D, C2600E
E-MC-S48A			 For measurements with stylus pointing downward Standard accessory for S3000A
E-MC-S51A			 For measurements with stylus pointing downward For C2600E, S3000A
E-MG-S02A	• []]]] •]38	Pitch diameter: 7.9mm Pitch: 15mm	• Dimensions: $144^{\text{W}} \times 38^{\text{D}} \times 49^{\text{H}}\text{mm}$
E-MG-S24A	90° 1 (Edge line length)	Tip radius: 0.1μm or less Material: Knife edge diamond	
E-TF-R25A		Input: 90V – 240V Output: 100V Capacity: 2.1 KVA	 Specify the input voltage Dimensions: 300^w × 350^p × 350^Hmm Weight: 45 kg
E-TF-S14A		Input: 100V Output: 100V ±2% Capacity: 1 KVA	 Dimensions: 150^w × 415^p × 250^μmm Weight: 22 kg
	Model DT58526 E-MC-S24B E-MC-S0B E-MC-S34A E-MC-S34A E-MC-S48A E-MC-S51A E-MG-S02A E-MG-S02A E-MG-S24A E-MG-S1A E-MG-S02A E-MG-S02A E-MG-S1A E-MG-S02A E-MG-S02A	Model Outer Appearance DT58526 99	Model Outer Appearance Outer Appearance DT59526 96 96 98



E35A Accessories

Name	Model	Outer Appearance	Specifications	Remarks
Pickup	E-DT-SM10A	$\begin{array}{c} 68.6 \\ 56 \\ 2.9 \\ 1.5 \end{array}$	5mmR, 90° conical diamond, 4mN	 For ordinary measurements Standard accessory
Pickup	E-DT-SM11A	$ \begin{array}{c} 68.3 \\ 14.5 \\ 41.2 \\ 41.2 \\ 1.5 \end{array} $	5mmR, 90° conical diamond, 4mN	 For small holes Min. inner dia.: \$\$\phi\$5mm
Pickup	E-DT-SM12A	$ \begin{array}{c} 68.3 \\ 14.5 \\ 41.2 \\ 12.6 \\ 1.5 \\ 1.5 \\ 1.5 \\ 1.5 \\ 1.5 \\ 12.6 \\$	5mmR, 90° conical diamond, 4mN	 For extra small holes Min. inner dia.: φ3mm
Pickup	E-DT-SM13A		5mmR, 90° conical diamond, 4mN	 For deep grooves Max. depth: 7mm
Standard piece	E-MC-S24B		Calibration surface: Approx. 3.1 μ mRa Actual measured value denoted	 For magnification calibration and checking stylus Standard accessory
Adjustment tool (for rear measurements)	E-WJ-S64A			Standard accessory
Adjustment tool (for front measurements)	E-WJ-S80A			
Nose piece (for cylinders)	E-WJ-S85A			
Nose piece (for flat surfaces)	E-WJ-S88A			
Long hole extension adapter	DT57506			
Adapter for side direction measurements	DT57507			
Adapter for hole measurements	E-WJ-S86A			
Magnetic stand	E-ST-MAC			
Post mount holder	010 2050	M4 Post mount holder 0102050		
Post mount	E-CS-S26A	Magnetic stand e10 E-ST-MAC		• For <i>φ</i> 6
RS-232C cable	E-SC-S248A		Compatible with 9-pin Windows PC connector	Provided with communication sample program



SURFCOM·CONTOURECORD Options >>>

S130A Accessories

Name	Model	Outer Appearance	Specifications	Remarks
Compact measuring stand	E-ST-S130A			• Weight: Approx. 18 kg
Pickup	E-DT-SE18A	9.1 1.1 1.1 1.1 1.1 1.1 1.1 1.1	5μmR, 90° conical diamond, 4mN	
Pickup	E-DT-SE19A	9.1 1.1 1.1 1.1 1.1 1.1 1.1 1.1	2µmR, 60° conical diamond, 0.7mN	Standard accessory
Touch pen	E-MA-S54A			
Charger	E-MA-S56A			 Dimensions: 80^w × 85^D × 45^Hmm Weight: Approx. 400 g Charging time: 4 hours
Battery	E-MA-S61A			 Dimensions: 203^w × 58^b × 67^Hmm Weight: Approx. 1.2 kg
Carrying case	E-MA-S58A	EUS J		+ Dimensions: $800^{w} \times 600^{v} \times 400^{H}$ mm + Provided with casters
Roll foot	E-MA-S62A		Applicable OD: <i>\$</i> 60mm or more	 Only for skid type measurements Drive unit is placed on outer diameter of roll to make measurements
Roll foot	E-MA-S63A	016 060 → +20 20→ + * 016	Applicable OD: <i>\$</i> 60mm or more	 Only for skid type measurements Provided with drive unit spacer
Dust cover	E-MA-S64A			For protection of amplification indicator from dust
Pickup holder for all orientations	E-DH-S107A			Only for skid type measurements
Horizontal tracing pickup holder	E-DH-S17A			 Only for skid type measurements
Drive unit attachment	E-CA-S62A			 50mm drive unit is mounted to manual column (E-CL-S26A)
RS-232C cable	E-SC-S288A		Compatible with 9-pin Windows PC connector	When cable is connected



Consumables

Name	Model	Device Model	Applicable System	Remarks
PC card	E-MU-S50A		130A, 480A	• 15MB
Ceramic pen (red)	HC-503-RD		600D	• 5 pieces/box
Becording paper	F-CH-S21A		130A, 480A	• 10 rolls/box
		E-RC-S24A	E35A high speed printer	• Width: 58mm × 25m
Recording paper	E-CH-S25A	E-RC-S23A, E-RC-S25A	E35A compact printer, E35A compact printer II	 10 rolls/box Width: 58mm × 7m
			100B, 300B, 400B, 500B, 700B, 720B	
Recording paper		E-RC-SUTA/B	550A, 900A/B, 920A, 730A, 470A, 740A	• 10 rolls/box
neeerang paper		E-RA-S01A	200B	• Width: 50mm × 40m
		E-RA-S03A	200C	-
Becording paper	E-CH-S05B		570A, 590A, 750A, 790A	• 10 rolls/box
necoluling paper	E-01-303B	E-RC-S09A	440A, 470A, 740A, 900B, 920B	• Width: 60mm × 40m
Becording paper	E-CH-S02A		110A, 350A, 550A, 470A	
	_ 011 002.1		730A, 740A, 920	201005/004
Recording paper	JIS No.121	E-RC-XY16	600B/C/D	 100 sheets/leaflet A3 leaflet
Recording paper	SP-319	E-RC-XY17	600B/C/D	• 10 rolls/box
Ink cartridge	IC1BK04	EM 0000/0000		• Black
ink can inge	IC3CL04	EM-900C/930C		Color (3 colors in 1 cartridge)
lak ribboa	E-IR-SO1A		100A, 350A, 550A, 470A	
			730A, 740A, 920A	



Explanation of Surface Characteristics · Standards \rightarrow

Definition of Surface texture and Stylus instrument



Evaluation procedure of roughness ISO4288: '96

- 1. View the surface and decide whether profile is periodic or nonperiodic.
- 2. When the tolerance limit is specified, use the table shown on the left for condition
- 3. When the tolerance limit is not specified.
 - 3.1 Estimate roughness and measure it in corresponding condition in the table
 - 3.2 Change condition according with above result and measure it again
 - 3.3 Repeat "3.2" if the result does not reached the condition
 - 3.4 When the result reaches the condition, it will be the final value. Check it in shorter sampling length at non-periodic and change it if it meets.
- 4. Compare the result toward tolerance limit in accordance with following rule.

Upper limit - the 16% rule (Default)

Measure on the most critical surface. If not more than 16% of all value based on sampling length are exceed the limit, surface is acceptable.

- The first value does not exceed 70% of the limit. - The first three values do not exceed the limit
- Not more than one of the first six value exceed the limit.
- Not more than two of the first twelve value exceed the limit.
- or when $\mu + \sigma$ does not exceed the limit, the result is acceptable.

Lower limit - the 16% rule (shown as L)

Measure the surface that can be expected the lowest roughness. If not more than 16% of all sampling length are less than the limit, or when μ - σ is not less than the limit, the result is acceptable.

Max value - the max rule (when "max" suffix is added)

The value is acceptable when none of value in entire surface is over the limit.







Measuring condition: R-parameter ISO4288: '96

	Non-perio	dic profile				Measuring	g Condition
Ra,Rq, or	Rsk,Rku R∆q	Rz,Rv, or	Rp,Rc, Rt	Periodic profile or RSm		Sampling length:	Evaluation length
Ra	(<i>µ</i> m)	Rz	(µm)	RSm (mm)		ℓr= CutOff	ℓ n (mm) = $5 \times \ell$ r
Over>	Less≤	Over>	Less≤	Over>	Less≤	$\lambda c (mm)$	
0.006	0.02	0.025	0.1	0.013	0.04	0.08	0.4
0.02	0.1	0.1	0.5	0.04	0.13	0.25	1.25
0.1	2	0.5	10	0.13	0.4	0.8	4
2	10	10	50	0.4	1.3	2.5	12.5
		50	200	13	4	8	40

Measuring condition : P-parameter

Stylus radius	λs	λc	No. of ℓ p = n	S. length ℓ p	E. length ℓ n	
2 <i>µ</i> m	2.5 <i>µ</i> m	_	Length 1 featur (Plane, L	Length of	Length of feature	
5µm	8µm			feature		
10µm	25 <i>µ</i> m			(Plane, Line)		

Measuring condition: W-parameter

1501302: 02						
λc	λf	No. of ℓ w = m	S. length & w	E. length ℓ n		
λc (for roughness)	$n\lambda c$ (n: specified)	m: specified	λf	mλf		



Explanation of Surface Characteristics · Standards >>>>

Total height of profile

 Wt^{J} (Pt = Rmax at JIS'82)

evaluation length.

Basic surface texture parameters and curves

Amplitude parameters (peak and valley)

Rt

Pt

Rp Pp

 Maximum profile peak height Wp

The largest profile peak height Zp within a sampling length.

Rp, Pp, Wp = max
$$(Z(x))$$





The largest profile valley depth Zp within a sampling length.

Rv, Pv, Wv = min
$$(Z(x))$$



Rz Pz Wz Maximum height of profile (Rz = Ry at ISO4287 '84)

 $Wz \perp (Rz = Ry \text{ at } ISO4287 '84)$

Sum of height of the largest profile peak height Rp and the largest profile valley Rv within a sampling length.

$$Rz = Rp + Rv$$



Different from Rz at old ISO, ANSI & JIS

Rp2 Rp2 Rp5 Rv2 Rv2 Rv4 Rv4 Rv4 Rv4 Rv4

Sum of height of the largest profile peak height

Rt, Pt, Wt = max (Rpi) + max (Rvi)

Rp and the largest profile valley Rv within an

Rc Pc Wc

Mean value of the profile element heights Zt within a sampling length.



Profile element:

Profile peak & the adjacent valley

Rzjis Ten point height of roughness profile (Rz at JIS'94)

Sum of mean value of largest peak to the fifth largest peak and mean value of largest valley to the fifth largest valley within a sampling length.

$$Rz_{jis} = \frac{1}{5} \sum_{j=1}^{5} (Zpj + Zvj)$$



Annex of JIS only and confirm to JIS'94 Different from Rz at JIS'82

Amplitude average parameters

Ra Pa Arithmetical mean deviation

Arithmetic mean of the absolute ordinate values Z(x) within a sampling length.

Ra, Pa, Wa =
$$\frac{1}{L}\int_{0}^{L} |Z(x)| dx$$



 Rq
 Pq

 Root mean square deviation

 Wq

Root mean square value of the ordinate values Z(x) within a sampling length.



Ra75 Center line average (Old Ra, AA, CLA)

Arithmetic mean of the absolute ordinate value Z(x) in a sampling length of roughness profile with 2RC filter of 75% transmission.



Annex of JIS only Same as Ra at old ISO, ANSI & DIN



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Spacing parameters



Mean value of the profile element width Xs within a sampling length.



Parameter from bearing ratio curve and profile height amplitude curve

Material ratio curve of the profile (Abbott Firestone curve)

Curve representing the material ratio of the profile as a functional of level c.

Profile height amplitude curve

Sample probability density function of ordinate Z(x) within an evaluation length.

Hybrid parameters

Root mean square slope

Root mean square value of the ordinate slopes

dZ/dX within a sampling length.

R∆q

P∆q

W∆q



Rmr(c) Pmr(c) Material ratio of profile Wmr(c) ┘ (Rmr(c) = ex-tp)

Ratio of the material length of the profile elements MI(c) at a given level c to the evaluation length.





Rδc Ρδς

Profile section height difference Wδc-

Vertical distance between two section levels of given material ratio.



Height characteristic average parameters

Quotient of mean cube value of the ordinate values Z(x) and cube Pq, Rq, Wq respectively, within a sampling length.



Rku Pku Kurtosis of profile Wku

Quotient of mean quartic of the ordinate values Z(x) and 4th power of Pq, Rq, Wq respectively, within a sampling length.



Rmr Pmr Wmr

Relative material ratio

Material ratio determined at a profile section level R δ c, related to a reference co.







Explanation of Surface Characteristics · Standards >>>

Expanded surface texture parameters and curves

Confirm to ISO4287: '96, ISO12085: '96 & ISO13565-1: '96 / -2: '96 / -3: '98

Traditional local parameters

RmaxDINMaximum peak to valley heightRzDINAverage peak to valley height

Zi is the maximum Peak to valley height of a sampling length ℓ r.

RmaxDIN is the maximum Zi of 5 adjoining sampling length ℓ r in an evaluation length ℓ n. RzDIN is arithmetic mean of 5 Zi.



German old standard DIN4768/1: '90

R3z Base roughness depth

3Zi is the height of the 3rd height peak from the 3rd depth valley in a sampling length $\,\ell\,r.$

R3z is arithmetic mean of 3Zi's of 5 sampling lengths in an evaluation length ℓ n.

$$R3z = \frac{1}{n} \sum_{i=1}^{n} 3z^{i}$$



PcPeak density /cm: ASME B46.1: '95PPIPeaks per inch: SAEJ911HSCHigh spot count

Pc is the number of peaks counted when a profile intersects a lower boundary line –H and an upper line +H per unit length 1 cm. PPI shows Pc in 1 inch (25.4mm) unit length. HSC shows the number of peaks when the lower boundary level is equal to zero.



Parameters of surfaces having stratified functional properties ISO13565's



Height characterization using the linear material ratio curve ISO13565-2:'96



Height characterization using the material probability curve of ISO13565-3

Draw a material ratio curve on normal probability paper from the roughness profile 4 (primary profile) of an evaluation length.

Separate the material probability curve to 2 area, upper plateau area and lower valley area. **Rpq (Ppq)** parameter: slope of a linear regression performed through the plateau region. **Rvq (Pvq)** parameter: slope of a linear regression performed through the valley region.

Rmq (Pmq) parameter: relative material ratio at the plateau to valley intersection.



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Motif parameters of ISO12085: '96

Measuring condition

A (mm)

0.02

0.1

0.5

2.5

Default A=0.5mm, B=2.5mm, ℓ n=16mm

ℓn(mm)

0.64

3.2

16

80

 $\lambda s(\mu m)$

2.5

2.5

8

25

B(mm)

0.1

0.5

2.5

12.5

Motif

A portion of the primary profile between the highest points of two local peaks of the profile, which are not necessarily adjacent.

Motif depths Hj & Hj+1

Depth measured perpendicular to the general direction of the primary profile.

Motif length Ari or AWi

Length measured parallel to the general direction of the profile.



Roughness motif: Motif derived by using the ideal operator with limit value A. Limit value A: Maximum length of roughness motif to separate waviness motif. Upper envelope line of the primary profile (Waviness profile): Straight lines joining the highest points of peaks of the primary profile, after conventional discrimination of peaks. AR: Mean spacing of roughness motifs: The arithmetical mean value of the lengths ARi of roughness motifs, within the evaluation length, i.e.

 $AR = \frac{1}{n} \sum_{i=1}^{n} ARi$ (n: Total number of roughness motifs)

R: Mean depth of roughness motifs: The arithmetical mean value of the depths Hj of roughness motifs, within the evaluation length, i.e.



Rx: Maximum depth of roughness motifs: The maximum value of the depths Hj of roughness motifs, within the evaluation length.



Waviness motif: Motif derived on upper envelope line by using ideal operator with limit value B Limit value B: Maximum length of waviness motif

AW: Mean spacing of waviness motifs: The arithmetical mean value of the lengths Awi of waviness motifs, within the evaluation length, i.e.

A

$$W = -\frac{1}{n} \sum_{\ell=1}^{n} AW_{i}$$
 (n: Total number of wavines motifs)

W: mean depth of waviness motifs: The arithmetical mean value of the depths HWj of waviness motifs, within the evaluation length, i.e.



Wx: Maximum depth of waviness: The largest depth HWj, within the evaluation length. Wte: Total depth of waviness: Distance between the highest point and the lowest point of waviness profile.



Hint of surface texture measurement



Display aspect ratio & Stylus fall depth in valley

Roughness profile usually displayed as much magnified height deviations than wavelength.

Displayed valley looks sharp but actually wide. Stylus

can contact to bottom of valley. Depth error ε with stylus unable to contact on triangle

valley is; $\varepsilon = r_{tip} (1/\cos\theta - 1)$ $\theta < 15^{\circ}$, or H/L=0.1-0.01 on machined surface.



Profile distortion with cutoff

Roughness profile will have bigger profile distortion & smaller amplitude when cutoff λc is short.

Primary profile P

×2000



Roughness profile R phase correct $\lambda c 0.25$ mm

Roughness profile with 2RC filter λc 0.25mm have big distortion according to phase shift.



Explanation of Surface Characteristics • Standards >>>

Comparison of national standards of surface texture measurement

	ID. of national standard	JIS B0601-'82 JIS B0031-'82	ANSI B46.1-'85	NF E05-015('84) NF E05-016('78) NF E05-017('72)	ISO468-'82 ISO4287/1-'84 ISO4288-'85 ISO1302-'78
Specification		former Janan	former II S A	former France	former ISO
Primon	Profile format	Analog signal	Analog signal with	Analog signal	Analog signal
profile P	Evaluation length	1 sampling length	low pass filtering	not defined	
	Maximum height	Rmax (S indication)		Pt	
P profile	Ten point height	Rz (Z indication)			
parameter	Other P parameters			Pp, Pa, (Tp)c,	
	Motif parameters			R, AR, Kr, W, W'max, W't, AW, Kw	
	Indication of maximum height < 1.5µm	Rmax=1.6 Rmax=0.8		Pt 0.8 - 0.6	
	Unit of height	μm	μ m or μ in.	μm	μm
	Unit of length	mm	mm or in.	mm	mm
	Filter	2RC	2RC	2RC	2RC
Roughness profile R	Long cutoff	λc	λв	λc	λc
	Short cutoff		cutoff value 2.5µm		
	Sampling length	L=3 $ imes$ λ c or over	L:1.3-5mm@λB 0.25	l	l
	Evaluation length	TL=L=3 $ imes$ λ c or over	L:2.4-8mm@λB 0.8 L:5-15mm @λB 2.5	$L = n \times \ell$	$\ell n = n \times \ell$
	Maximum height		Peak-to-Valley Height (Rmax, Ry)	Ry	Ry
B profile	Maximum peak to valley height			Rmax	Rymax
Height	Ten point height		(Rz)	Rz	Rz
parameter	Average peak to valley height				Ry5
	Other peak height parameters		(Rp)	Rp	Rp, Rpmax, Rp5, Rm, Rc
	0.25mm	Rmax, $Rz \le 0.8 \mu m$		not defined	$0,1 < Rz, Ry \le 0,5 \mu m$
ℓ r & λ c for peak height parameter	0.8mm	$0.8 < R_{max}, Rz \le 6.3 \mu m$		not defined	$0,5 < Rz, Ry \le 10 \mu m$
	2.5mm	$6.3 < R_{max}, Rz \le 25 \mu m$		not defined	10 < Rz, Ry ≤ 50 <i>µ</i> m
Indication of Maximum height in case of Rz < 1.5μ m				Rmac 1.6	Ry = 1.6
R profile	Arithmetic average	Ra (a indication)	Ra	Ra	Ra
averaging parameter	root mean square		(Rq)	Rq	Rq
	Skewness, kurtosis		(Skewness, Kurtosis)	Sk, Ek	Sk
	0.25mm	optional	0.0063 < Sm ≤ 0.05µm	not defined	0,02 < Ra ≤ 0,1 <i>µ</i> m
ℓ r & λ c for Ra on non-periodic profile	0.8mm	Ra ≤ 12.5 <i>µ</i> m	0.02 < Sm ≤ 0.16µm	not defined	0,1 < Ra ≤ 2µm
	2.5mm	12.5 < Ra ≤ 100 <i>µ</i> m	$0.063 < Sm \le 0.5 \mu m$	not defined	2 < Ra ≤ 10µm
Indication of Ra in case of 1.5 < Ra < 3.1μ m		3.2 1.6	125 63	Ra 1.6 - 3.2	3.2 1.6 N7
	Mean spacing		Roughness spacing	Sm	Sm
R profile other	RMS slope			Δq	Δq
parameter	material ratio		(tp)		tp
	Other parameters		(Peak count Pc)	S, Δa, λa, λq	S, Δa, λa, λq, Lo, D
Comparison rule of	Average	average value of all sampling lengths	average value of all sampling lengths	not defined	
measured value with	16% rule			not defined	16% rule default
LOIEFAILCE IITHIS	Maximum rule			not defined	Max rule for parameter with suffix "max"

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BS1134 part 1-'88 BS1134 part 2-'90	DIN4768-'90 DIN4771-'77 DIN4775-'82 DIN4776-'90 DIN4777-'90	JIS B0601-'94 JIS B0031-'94	ASME B46.1-'95	ISO4287:'97 (JIS B0601:'01) ISO4288:'96 (JIS B0633:'01) ISO12085:'96 (JIS B0631:'00) ISO13565's, (JIS B0671's) ISO1302:'02	
former U.K.	former Germany	former Japan	U.S.A.	EU, U.K. & Japan	
without filtering	Analog signal Digital data without filtering without filtering		Digital data with λ s filter	Digital data with λ s filter	
	0,5, 1,5, 5, 15 & 50mm			= 1 sampling length = Length of the measured feature	
	Pt			Pt, Pz(=Pt)	
				Pp, Pv, Pc, Pa, Pq, Psk, Pku, PSm, P Δ q, Pmr(c), P δ c, Pmr, Ppq, Pvq, Pmq	
				R, AR, Rx, W, AW, Wx, Wte	
	15 / Pt 1,6			U 0.008- /Pt 1.5	
μ m (μ in)	μm	μm	μ m (or μ in.)	μm	
mm (inch)	mm	mm	mm (or in.)	mm	
2RC	Phase correct	Phase correct	Phase correct (or 2RC)	Phase correct	
λв	λc	λc	λc	λο	
			λs	λs	
ℓ r	l c	ℓ r	Cutoff length: 1	l r	
$\ell e = 5 \times \ell r$	5×ℓ c	$\ell e = 5 \times \ell r$	$L = 5 \times \ell$	$\ell e = 5 \times \ell r$ Calculate for each sampling length ℓr	
	Rt	Maximum height Ry in 1 ℓ r	Rt	Maximum height Rz in 1ℓr or total height Rt in 1ℓe	
Ry	Maximum two point height Rmax		Rmax	Rz max	
Rz		Ten point height Rz			
	Ten point height Rz	Maximum height Ry	Rz	Average method Rz	
			Rp, Rpm, Rv	Rp, Rv, Rc	
$0,1 < Rz \le 0,5 \mu m$	0,1 < Rz ≤ 0,5 <i>µ</i> m	0.1 < Rz, Ry ≤ 0.5µm	0.02 < Ra ≤ 0.1µm	0.1 < Rz ≤ 0.5µm	
0,5 < Rz ≤ 10 <i>µ</i> m	0,5 < Rz ≤ 10 <i>µ</i> m	0.5 < Rz, Ry ≤ 10 <i>µ</i> m	0.1 < Ra ≤ 2 <i>µ</i> m	0.5 < Rz ≤ 10 <i>µ</i> m	
10 < Rz ≤ 50 <i>µ</i> m	10 < Rz ≤ 50 <i>µ</i> m	10 < Rz, Ry ≤ 50 <i>µ</i> m	2 < Ra ≤ 10µm	10 < Rz ≤ 50µm	
Ry =1.6	Rmax = 1,6	Ry1.6~0.8 λc 0.25	Rmax = 1.6	U 0.008-2.5/Rz 1.5 L -0.25/Rz 0.7	
Ra	Ra	Ra	Ra	Ra	
			Rq	Rq	
			Rsk, Rku	Rsk, Rku	
0,02 < Ra ≤ 0,1 <i>µ</i> m	0,02 < Ra ≤ 0,1 <i>µ</i> m	0.02 < Ra ≤ 0.1 <i>µ</i> m	0.02 < Ra ≤ 0.1µm	0.02 < Ra ≤ 0.1µm	
0,1 < Ra ≤ 2 <i>µ</i> m	0,1 < Ra ≤ 2 <i>µ</i> m	0.1 < Ra ≤ 2 <i>µ</i> m	0.1 < Ra ≤ 2 <i>µ</i> m	0.1 < Ra ≤ 2µm	
2 < Ra ≤ 10µm	2 < Ra ≤ 10 <i>µ</i> m	2 < Ra ≤ 10 <i>µ</i> m	2 < Ra ≤ 10µm	2 < Ra ≤ 10µm	
3.2 N8 1.6 N7	3,2 1,6	1.6~3.2	3.2	U"2RC" -0.8/Ra75 3.1 L"2RC" -0.8/Ra75 1.5	
Sm		Sm	Sm	RSm	
			Δq	RΔq	
tp		tp	tp	Rmr(c)	
s		S	Htp, ∆a, SAE Peak PPI, Peak density Pc	Rδc, Rmr, Rpk, Rvk, Rk, Mr1, Mr2, Rpq, Rvq, Rmq	
		average value of all	not defined	average value of all sampling lengths	
16% rule 16% rule for Ra. Rz			not defined	16% rule default	
Max rule for parameter Max rule for with suffix "max" Rmax			not defined	Max rule for parameter with suffix "max"	

